

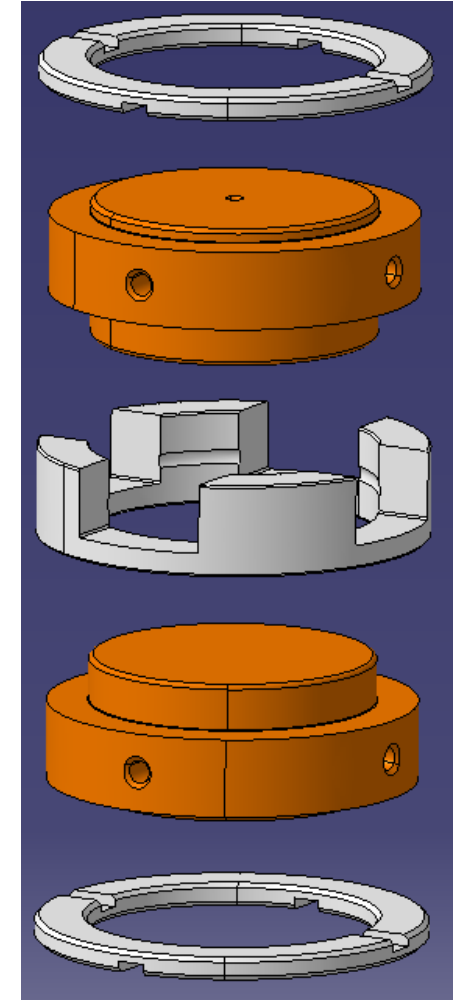
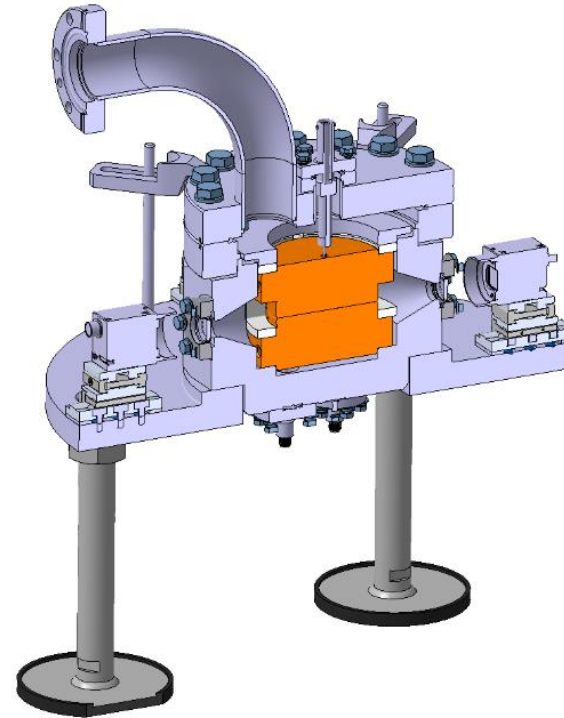
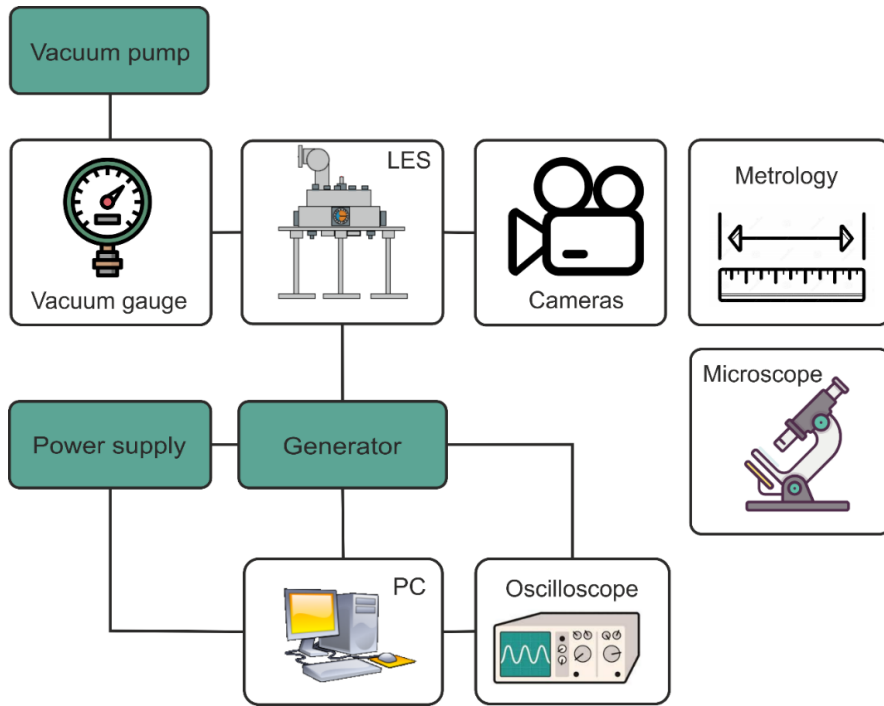


# Recent progress at pulsed dc systems

Iaroslava Profatilova

# Pulsed DC System at CERN

vacuum system for high-gradient studies



a)

b)

c)

Fig. 2. Pulsed DC system at CERN: a) schematic of the equipment, b) 3D-model for Large Electrodes System (LES), c) electrodes assembly.

Pressure during the test less than  $1E-7$  mbar.

# Marx generator

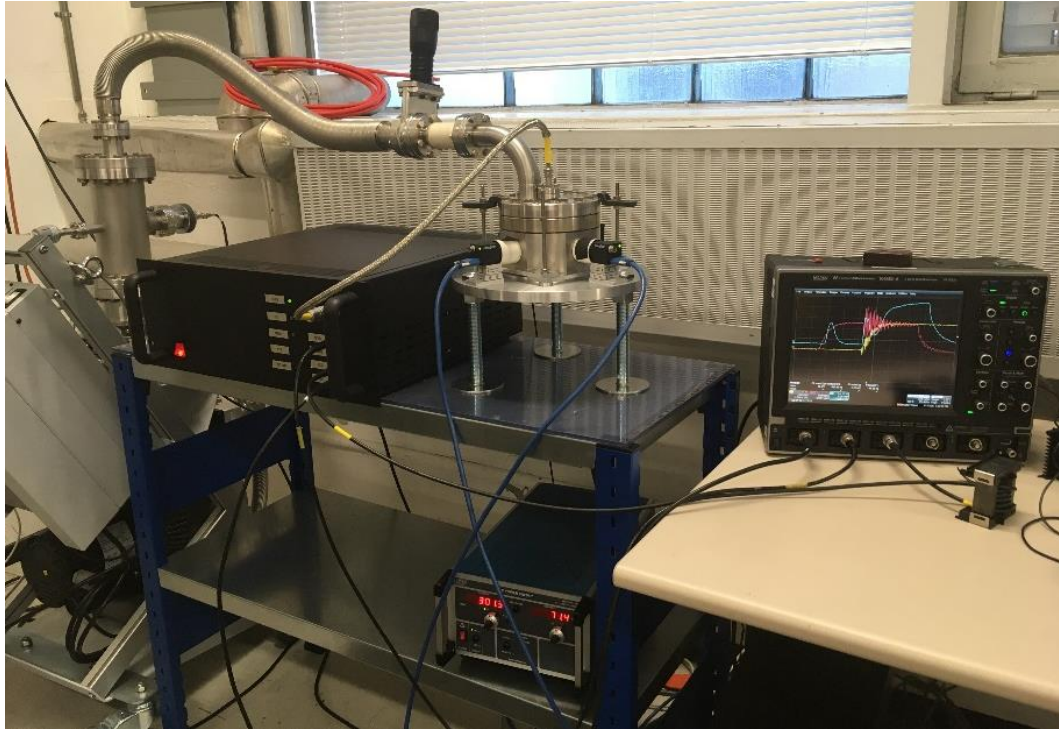


Fig. 3.1. Photo of Marx generator together with LES.

Repetition rate: up to 6 kHz  
 Pulse length: 500 ns – 1 ms.

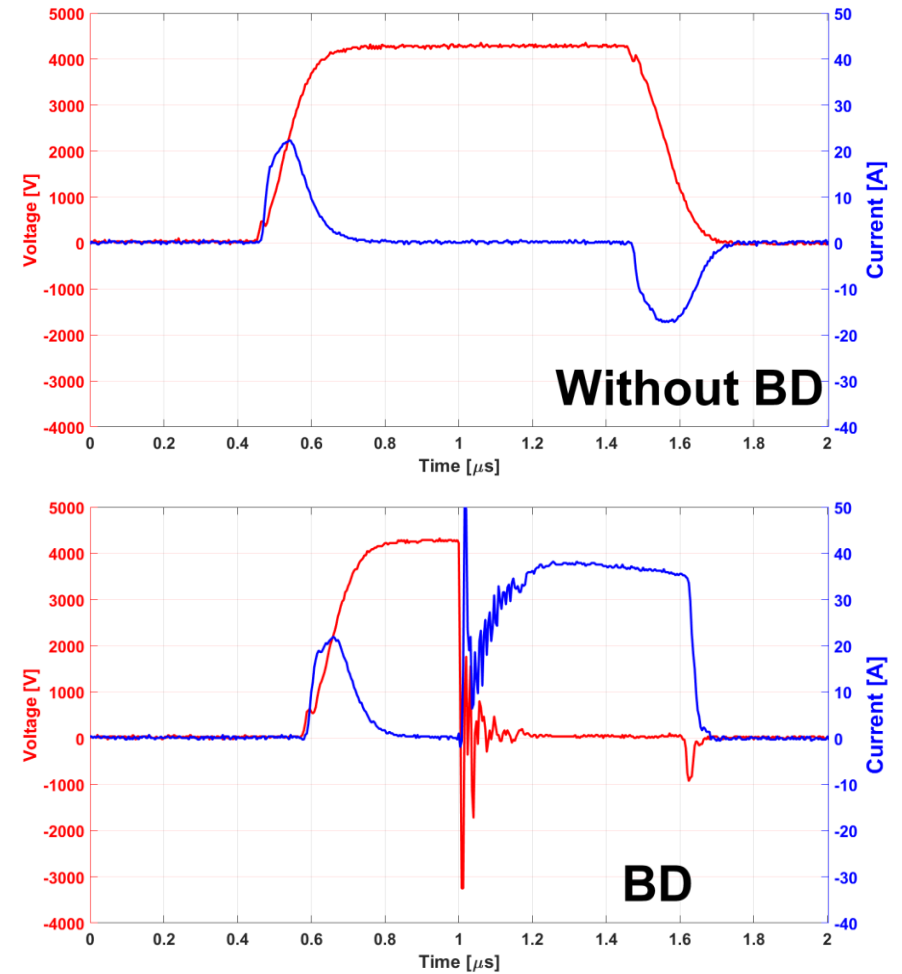
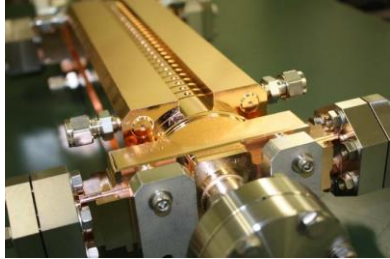
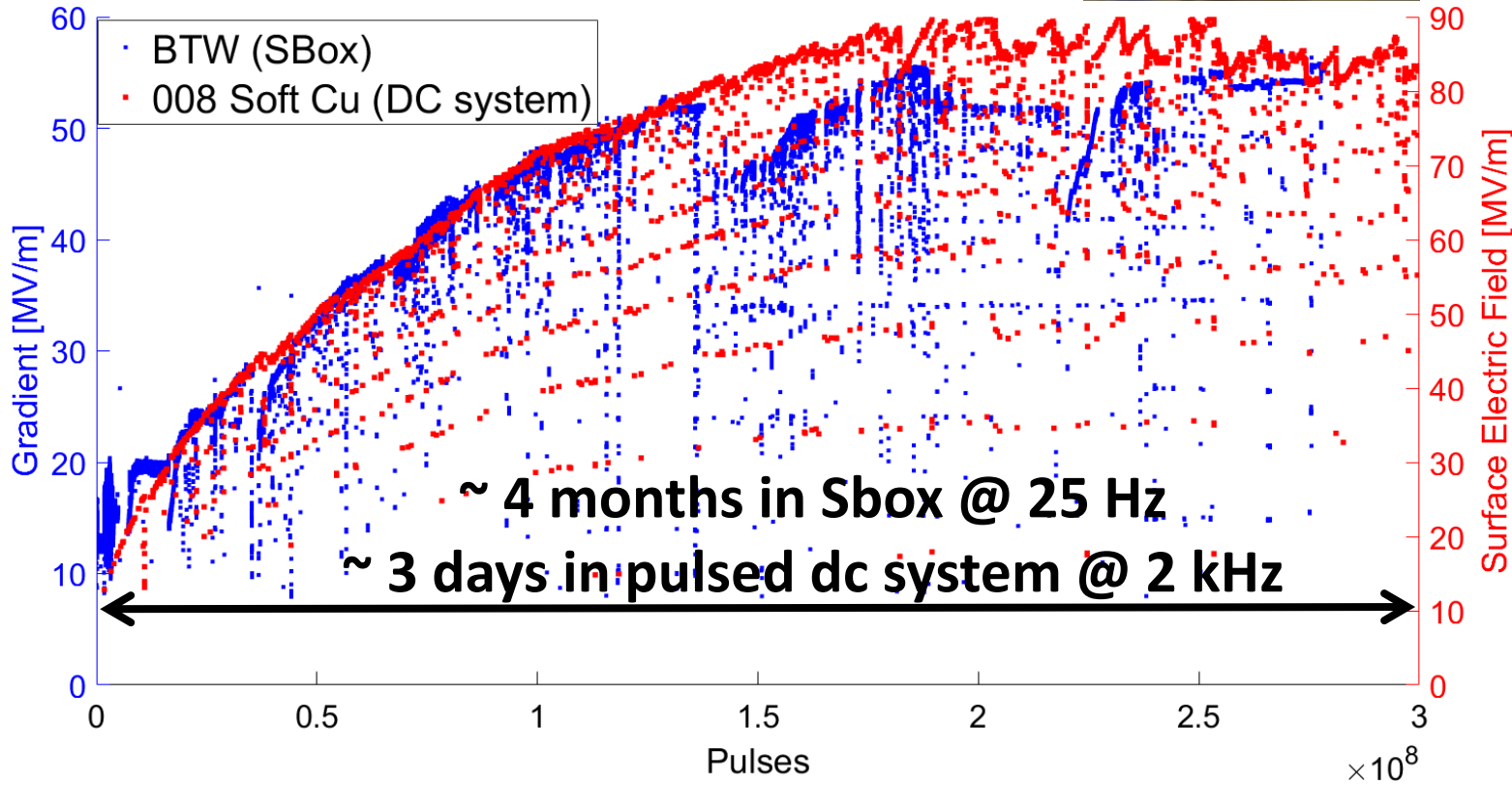


Fig. 3.2. The waveforms taken with Marx generator and LES with 1  $\mu$ s pulse (0.6  $\mu$ s delay is used in BD case).

# Conditioning in RF and DC



Marx generator, 6kHz



XBox-3: 6 MW, 400 Hz!

...courtesy of Xboxes team

# Comparison of heat-treated and as-machined copper

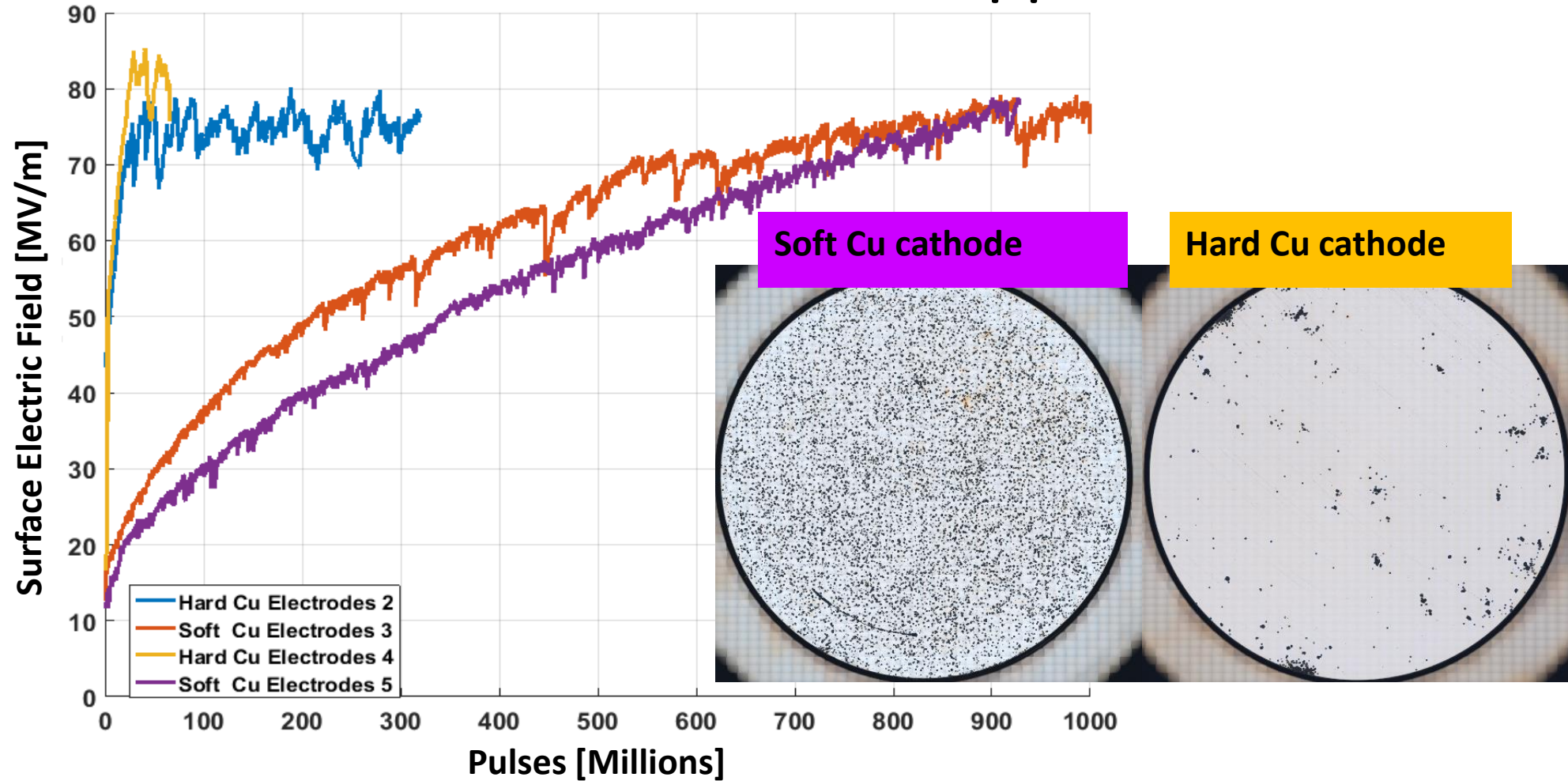


Fig. 5. Conditioning curves from tests at Pulsed DC System taken with HRR circuit, 16.7  $\mu$ s pulse lengths and 60  $\mu$ m gap distances.



# Overview of DC systems



CERN systems (Yinon, Jan, Sagy talk, Ruth poster)

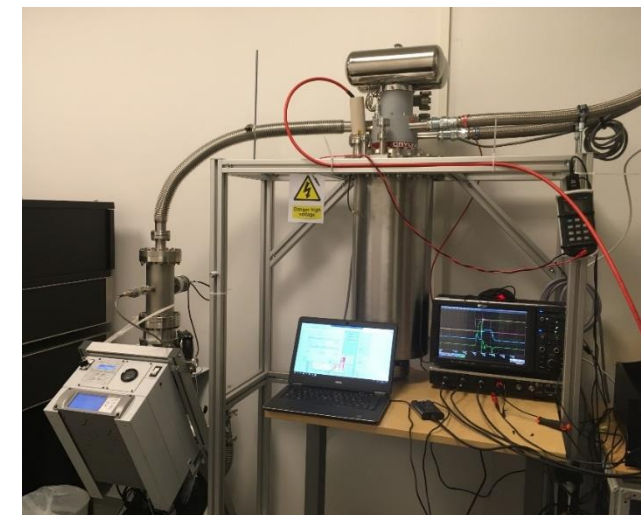


Helsinki  
(see Anton's talk)



UPPSALA  
UNIVERSITET

Uppsala  
(see Marek's talk)

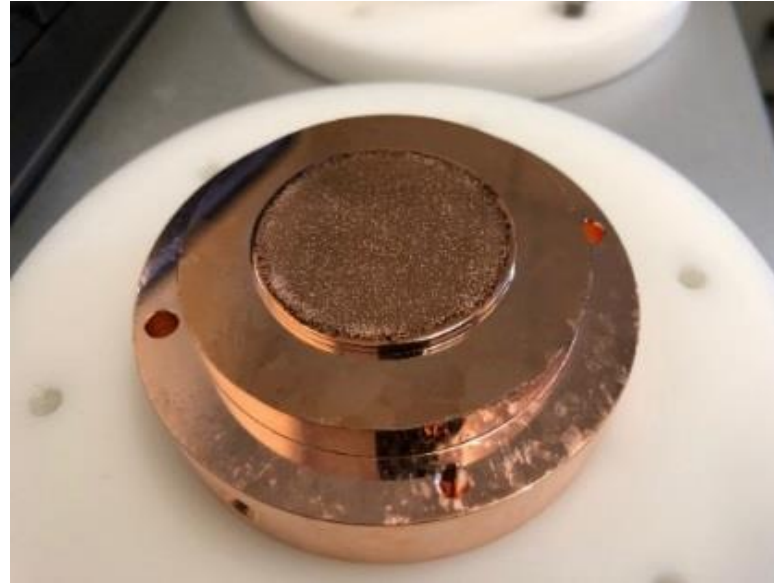


# Electrodes geometry

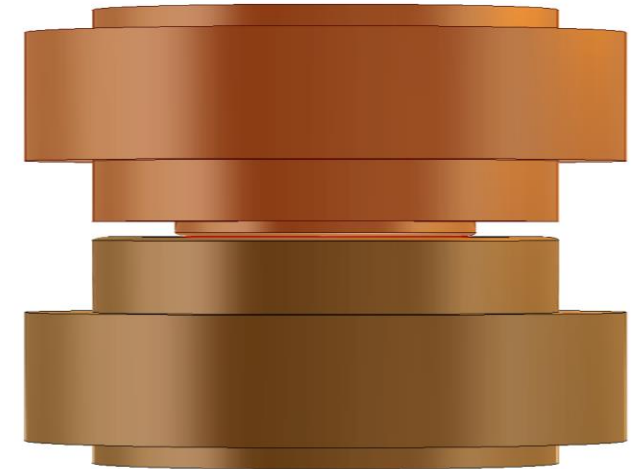
**Cathode**



**Anode**



**Electrodes assembly**



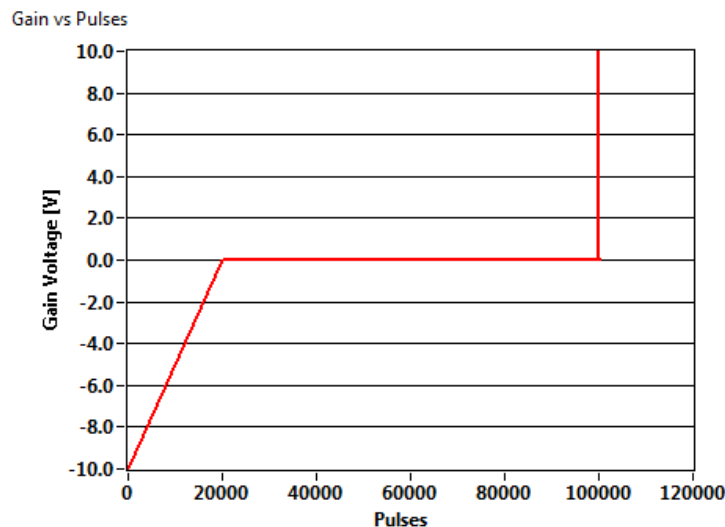
The equal electrodes geometry for all 4 pulsed dc systems is started to be implemented.



# Different tests in pulsed DC system



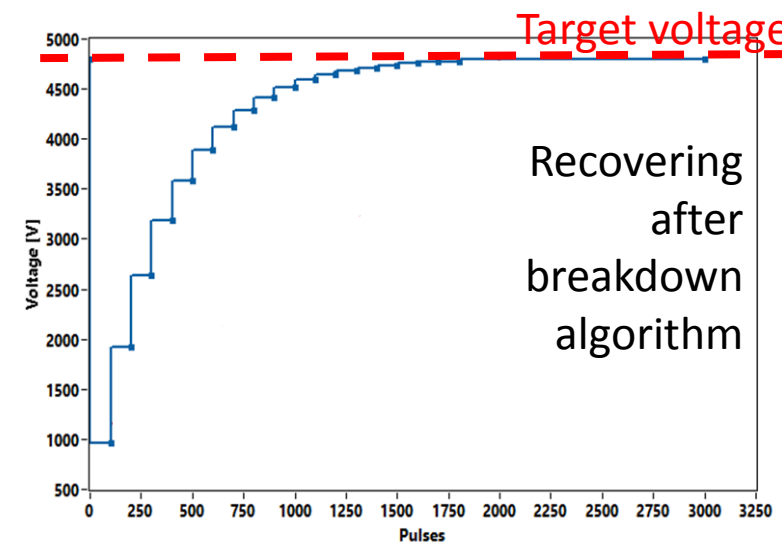
**Feedback mode**  
(initial conditioning,  
polarity changing,  
gap effect on E field)



Parameter	Value
Max number of pulses per cycle	100 000
Safe pulses	20 000
Gain voltage at 0	-0.17 MV/m
Gain after timeout	0.17 MV/m
Initial voltage	(~10 MV/m)
Max BDR	1E-5

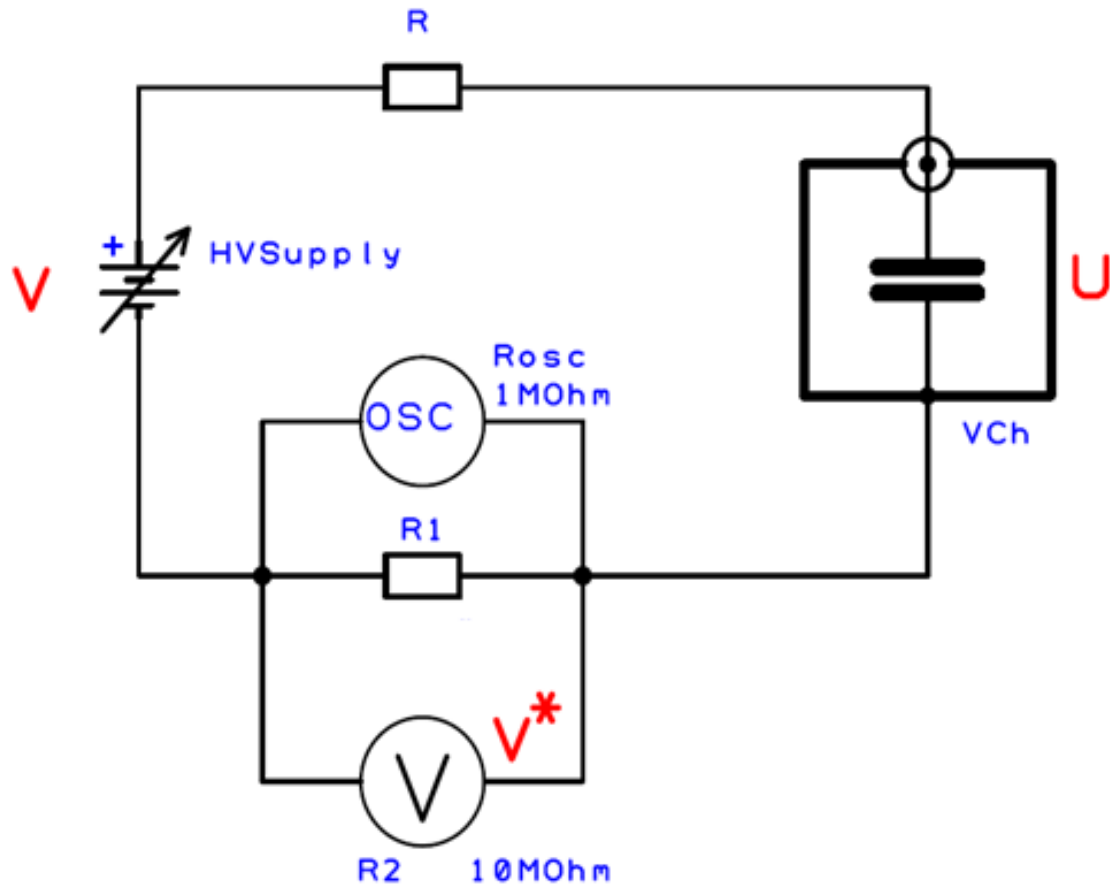
**Flat mode (BDR vs Rep Rate)**

**Field emission measurements**





# Field emission measurement



Voltage applied to the LES  
(anode-cathode voltage):

$$U = V - I \times R \quad (1),$$

V - voltage at power supply,  
R = 6.39 MOhm.

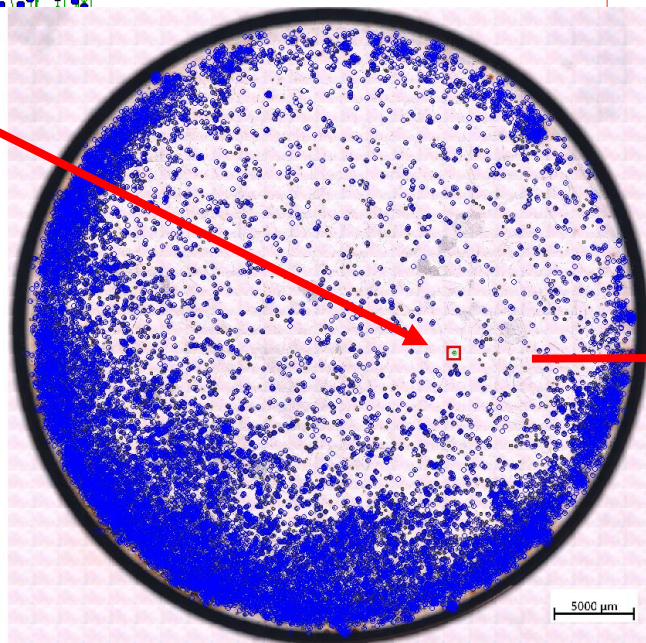
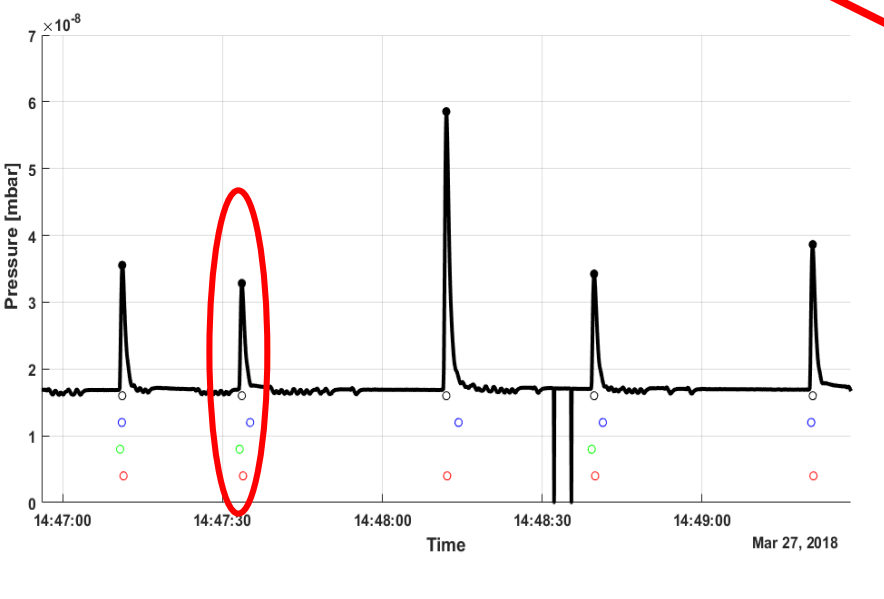
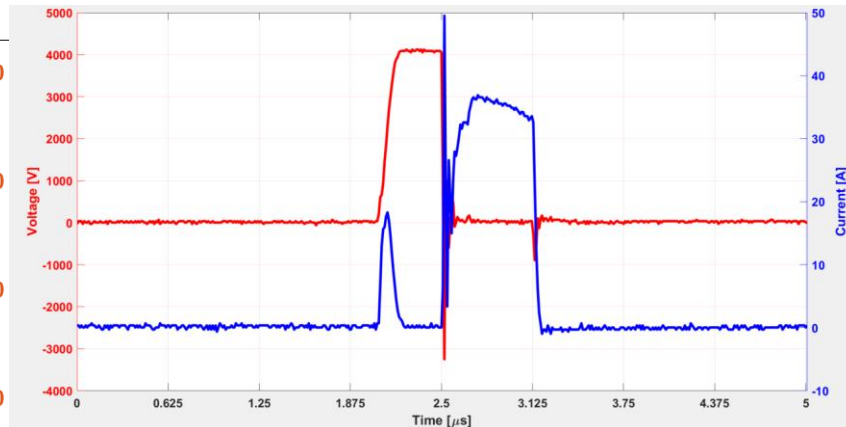
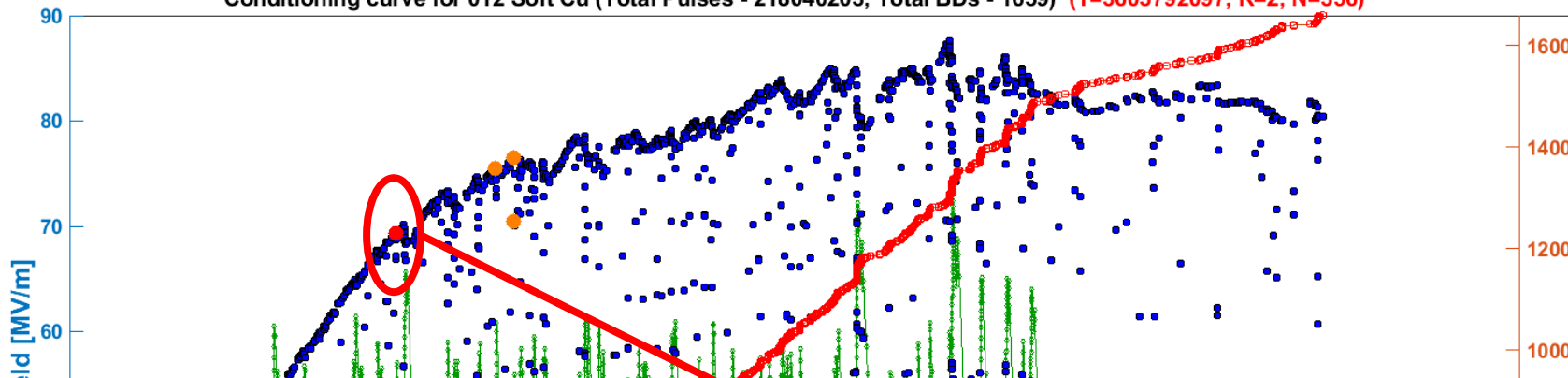
$I = \frac{V^*}{R^*}$ ,  $V^*$  - voltage at the multimeter.

$$\frac{1}{R^*} = \frac{1}{R_{osc}} + \frac{1}{R_1} + \frac{1}{R_2}, \quad R_1 = 100 \text{ kOhm} \Rightarrow$$

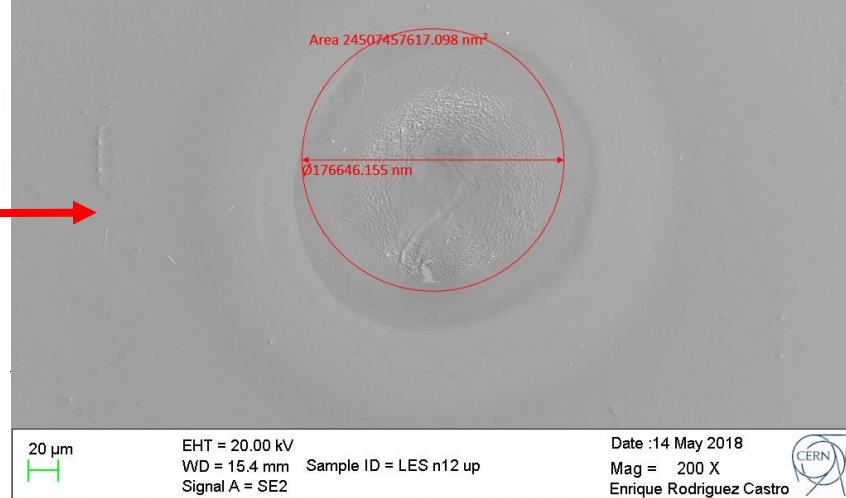
$$R^* \approx 90.1 \text{ kOhm}$$

Unique breakdown position determination.

Conditioning curve for 012 Soft Cu (Total Pulses - 218040203, Total BDs - 1659) (T=3603792097, R=2, N=356)



Conditioning test  
E field = 69.4 MV/m, BDs = 356



# BDs localisation

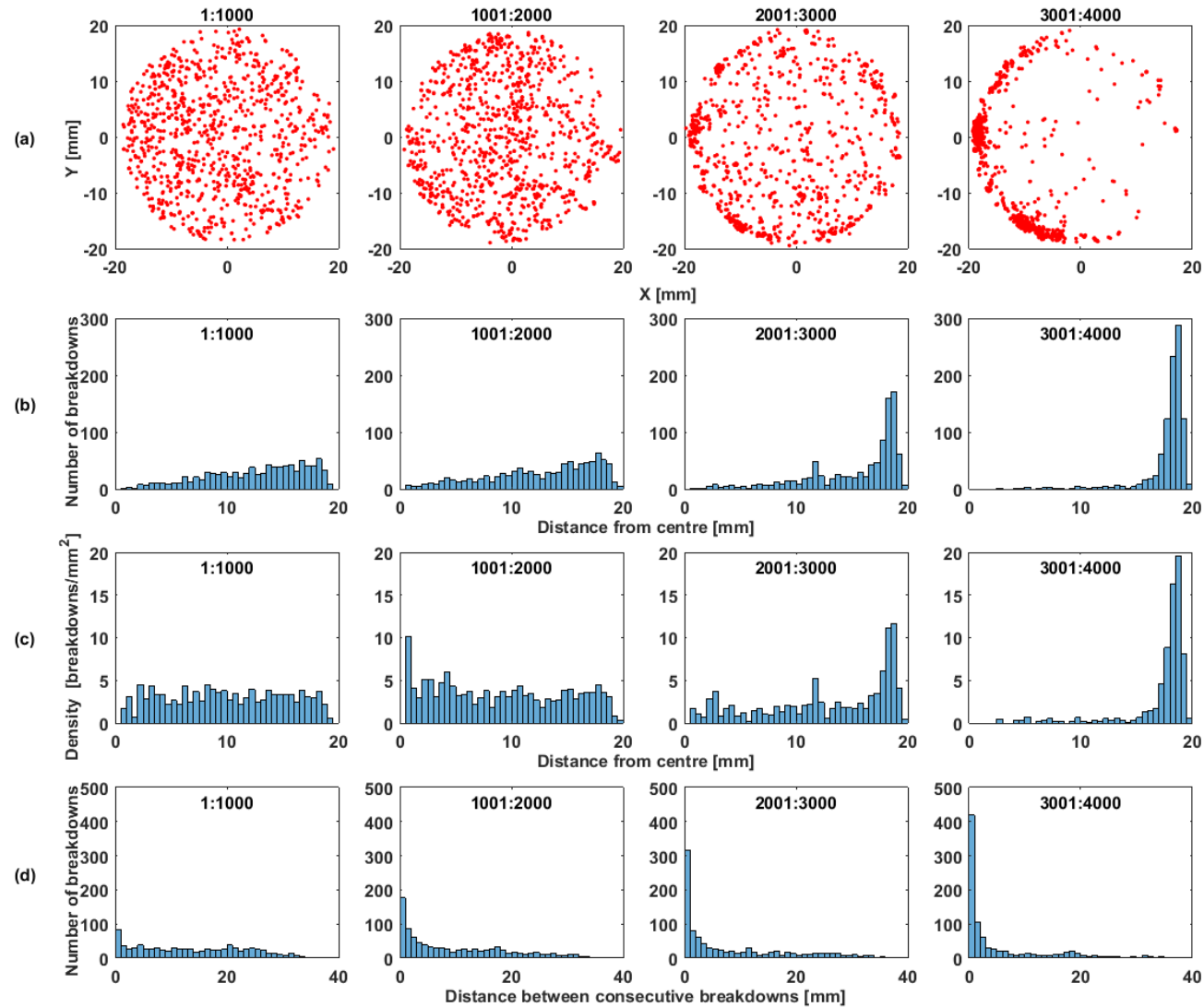
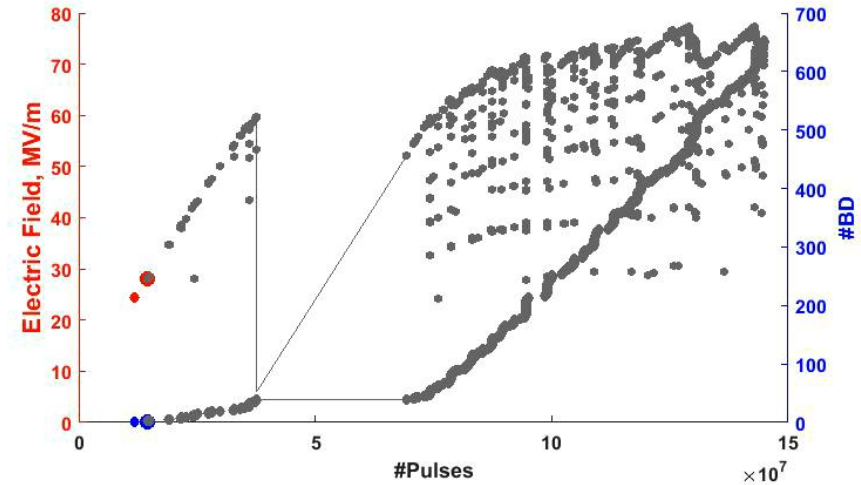
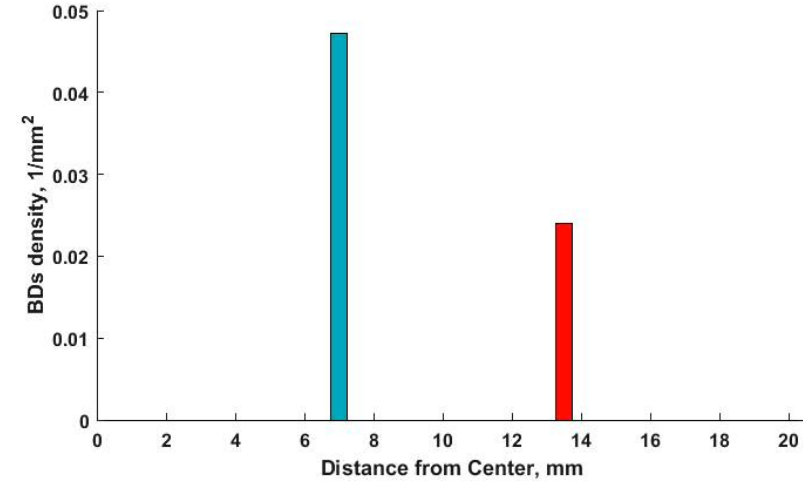
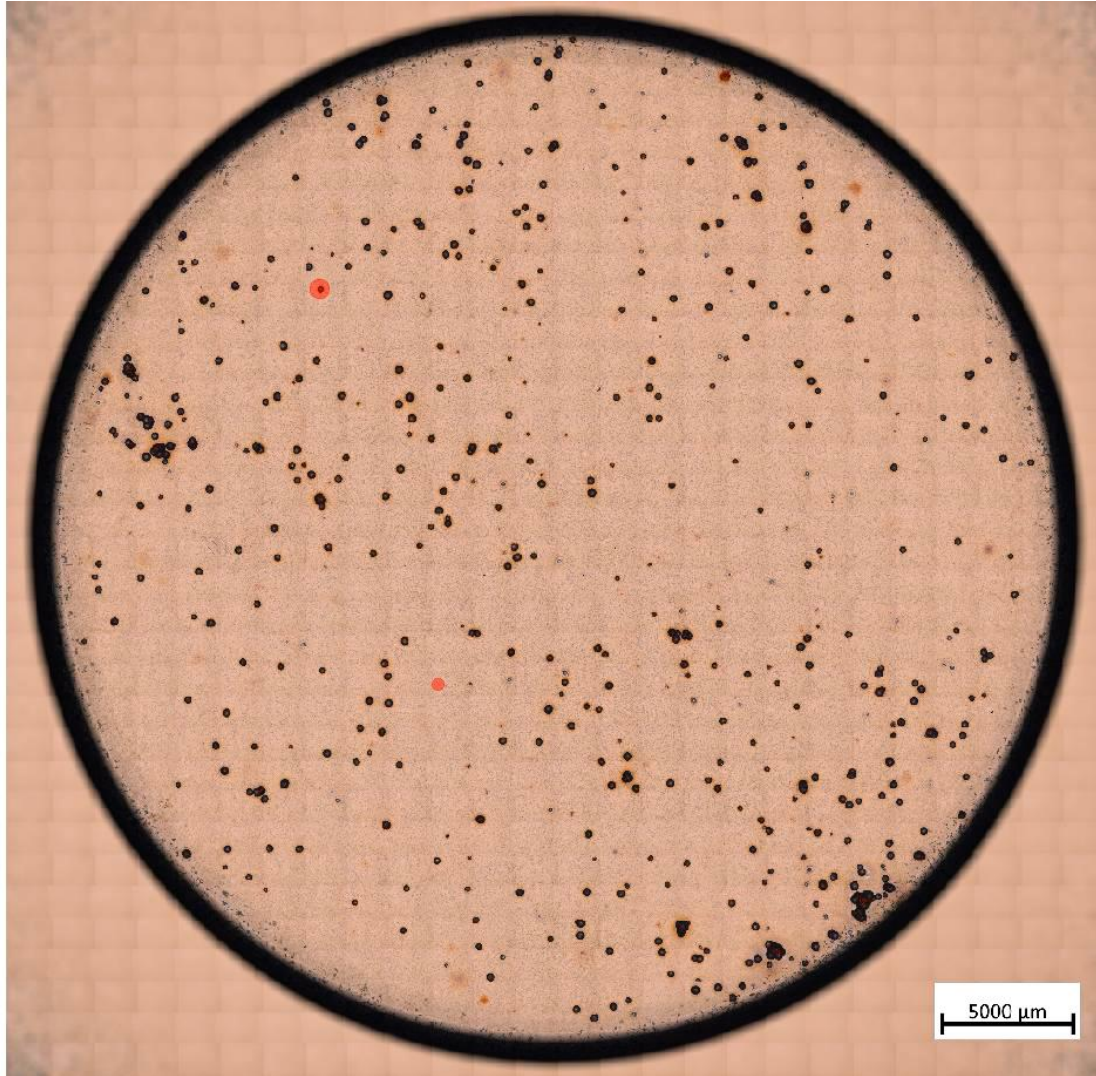


Fig. 11. Evolution of breakdowns on the surface for the Soft Cu electrodes for first 4000 events.

# Evolution of breakdowns





# Gap effect to the E field

# Gap effect to the E field

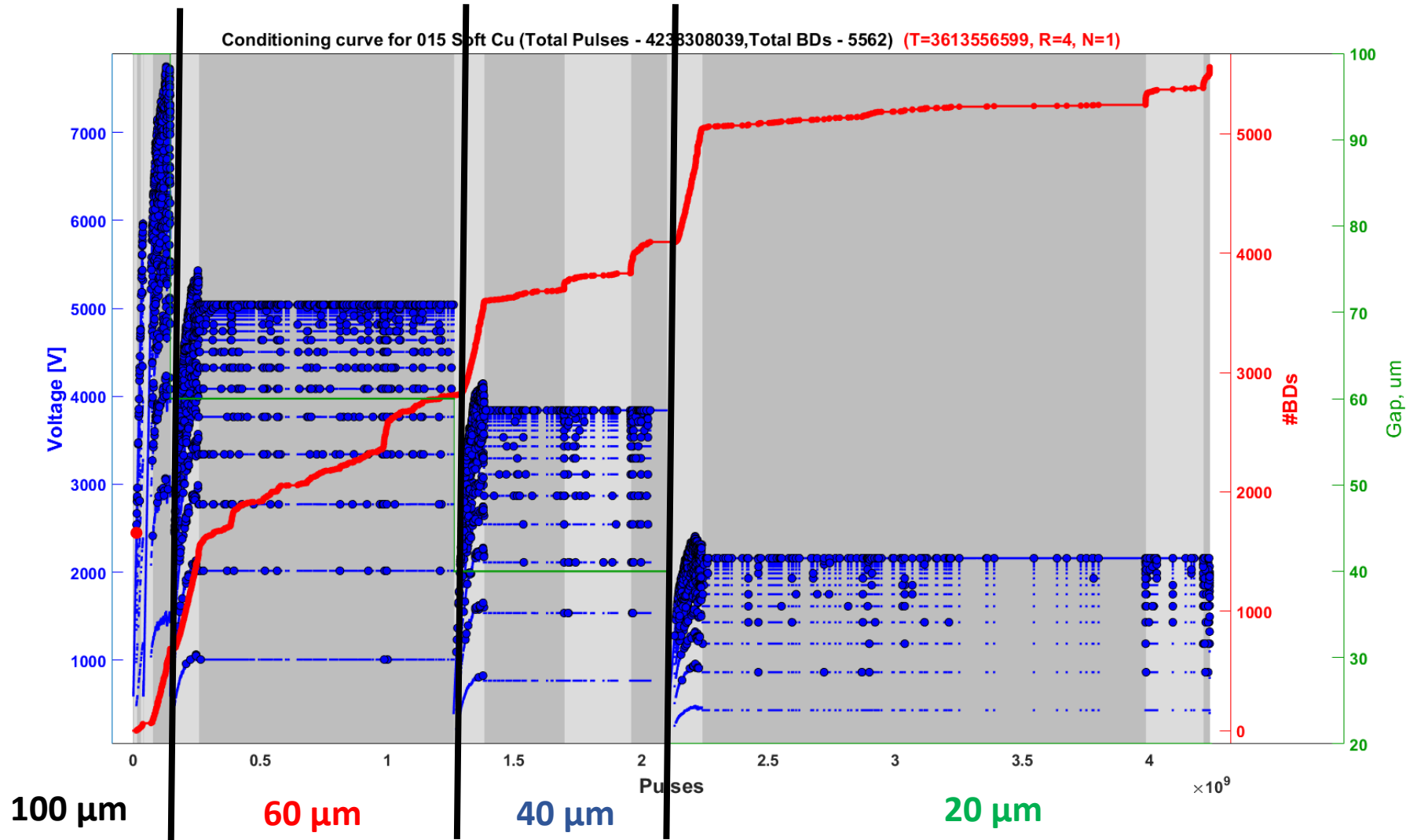


Fig. 14.  
Consequence of test  
with different gaps  
in pulsed dc system.

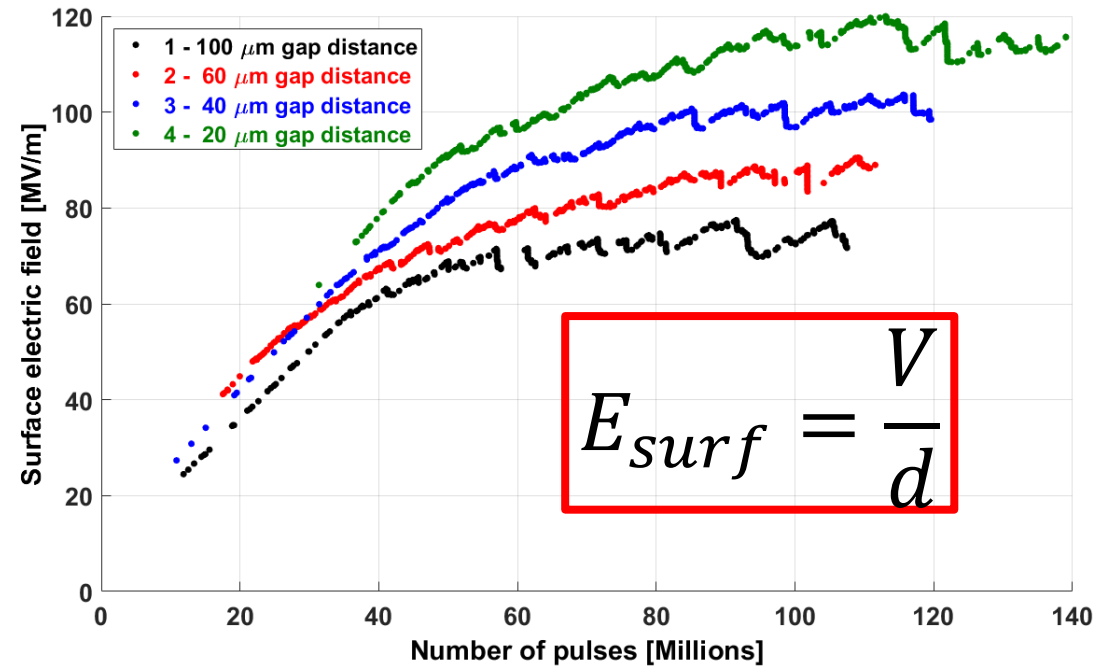
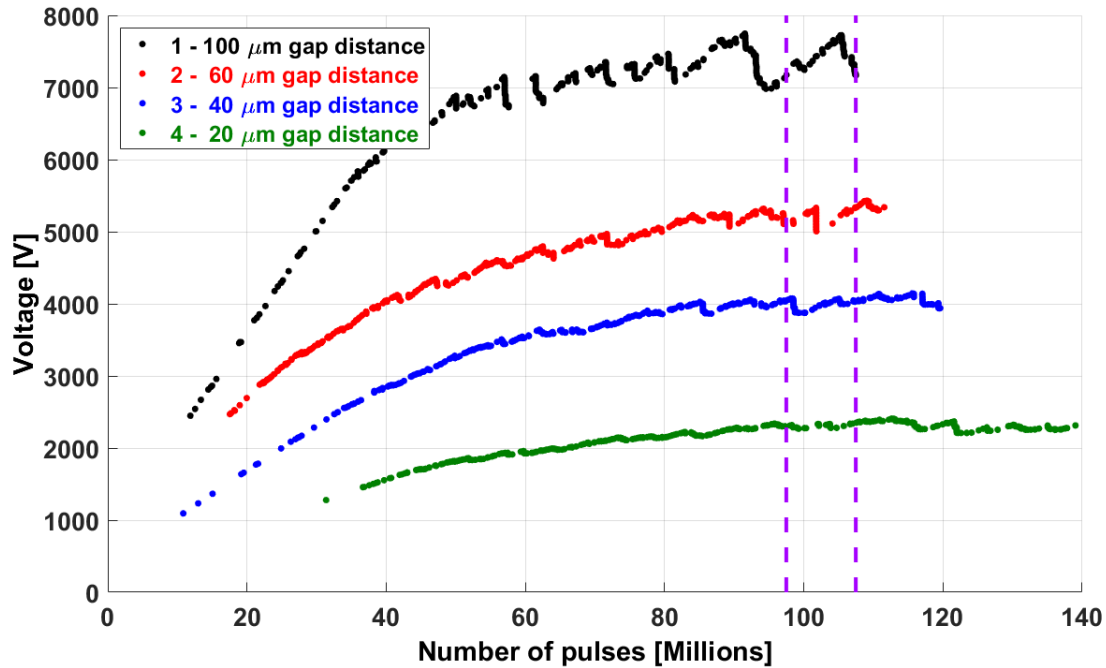
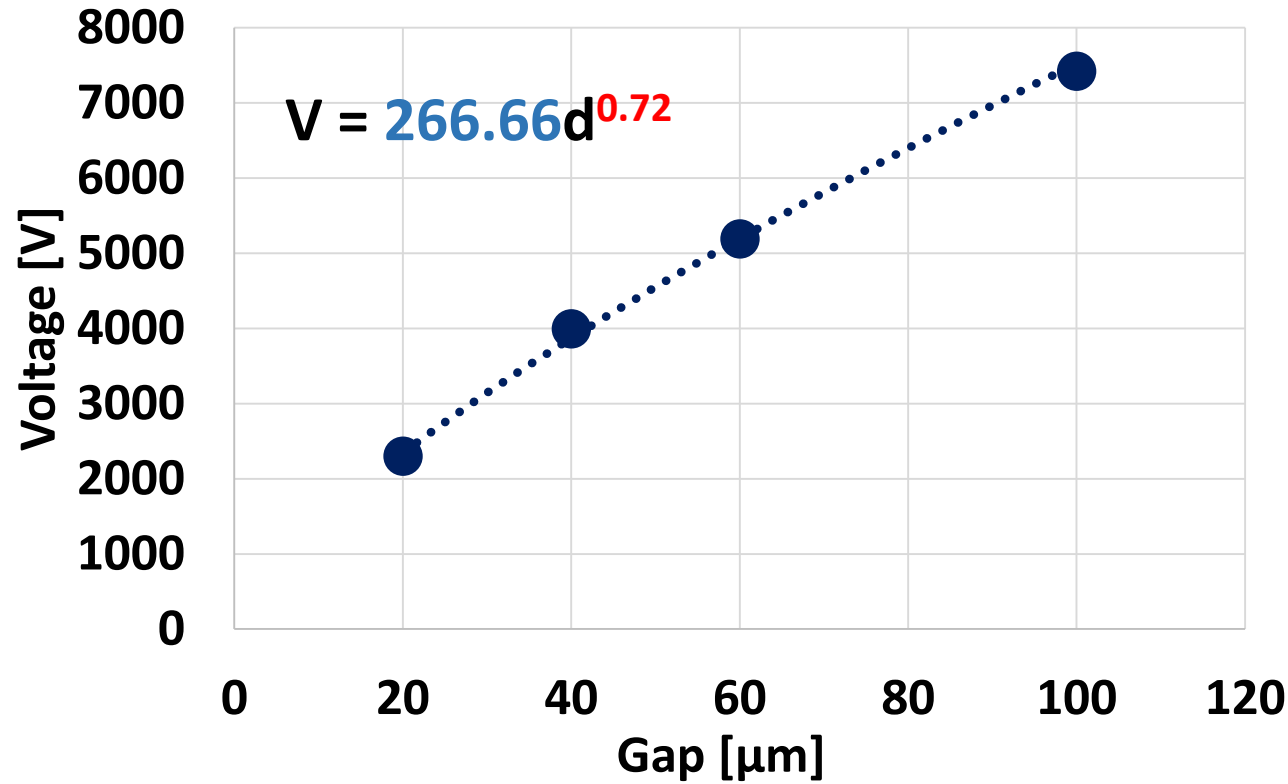


Fig. 15. Comparison of voltages and surface electric field value for the test with the different gaps. The purple lines show the window taken for analysis.



# Gap dependency



The averages of voltage during last 10 mins of pulses from conditioning curves are used for the plot.

JOURNAL OF APPLIED PHYSICS VOLUME 32, NUMBER 11 NOVEMBER, 1961

## New Derivation of the Vacuum Breakdown Equation Relating Breakdown Voltage and Electrode Separation

A. MAITLAND\*  
Research Department, Associated Electrical Industries (Manchester) Limited, Trafford Park, Manchester, England

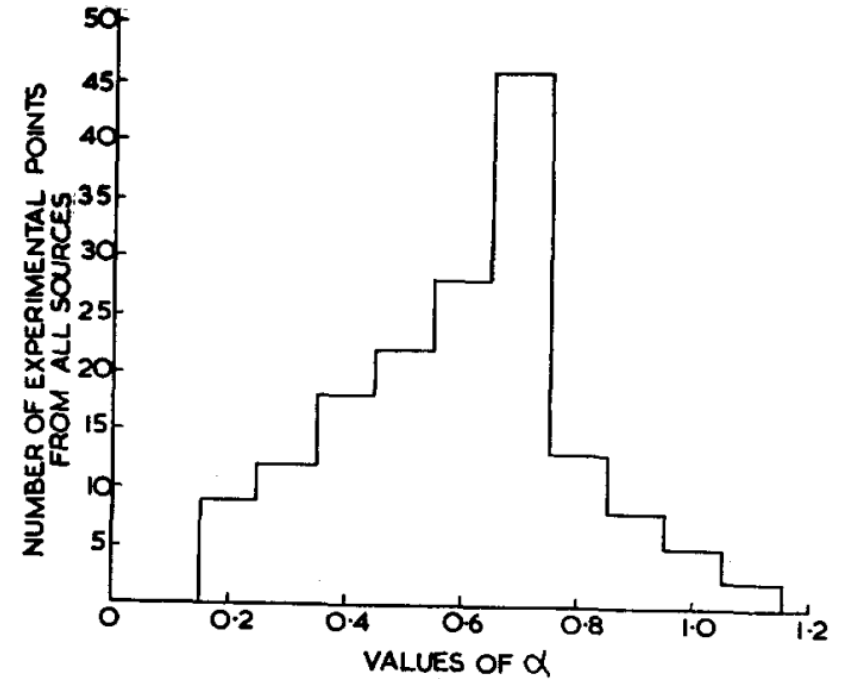
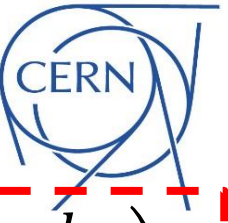


FIG. 1. Distribution of values of  $\alpha$  obtained from publications relating to plane or near-plane geometry.



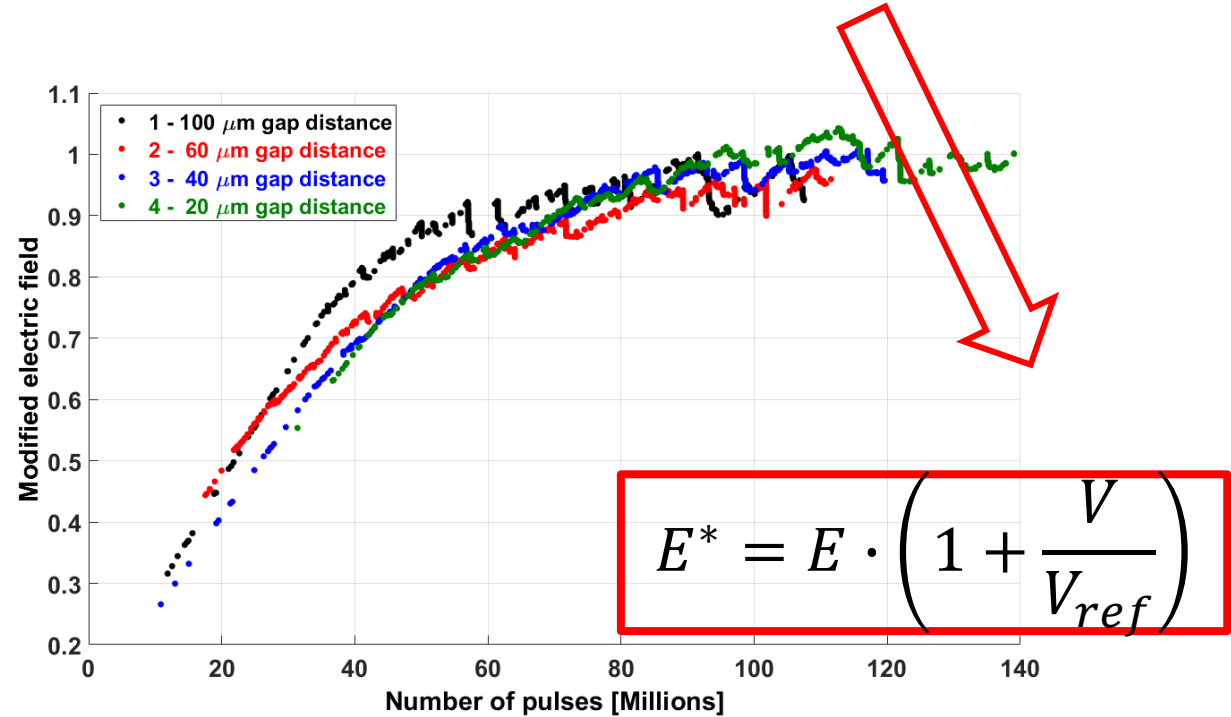
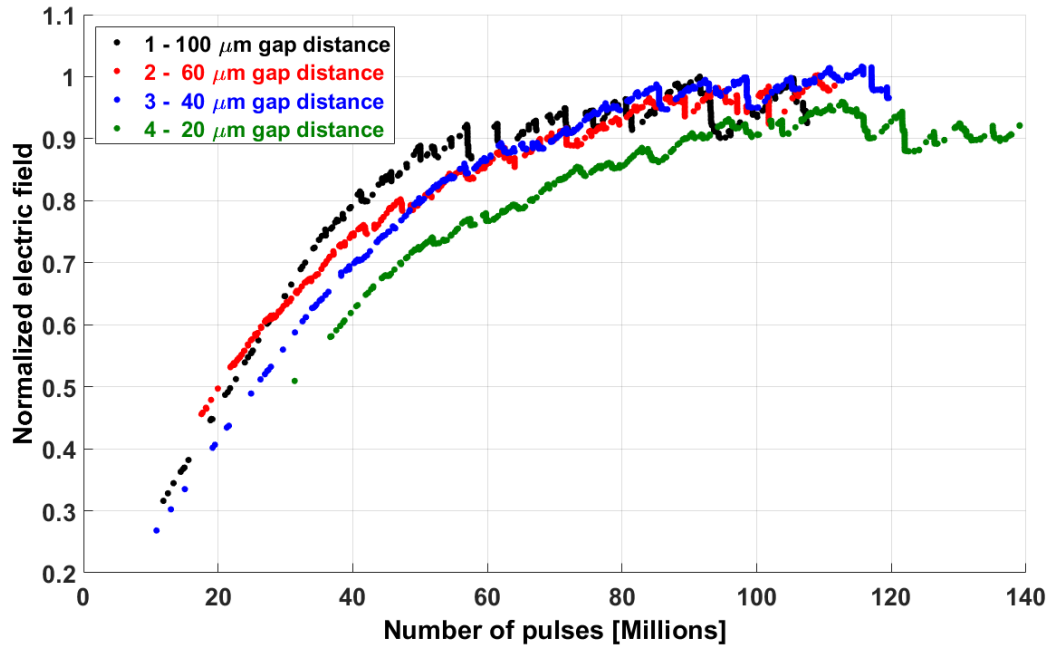


# Gap dependency



$$E_{norm} = \left( \frac{V}{V_{max}} \right) \times \left( \frac{d_{max}}{d} \right)^{0.7}$$

$$E_{mod} = \frac{V}{V_{max}} \cdot \frac{d_{max}}{d} \cdot \frac{1}{1.7} \cdot \left( 1 + 0.7 \cdot \frac{d}{d_{max}} \right)$$



$$V_{max} = 7747 V$$

$$d_{max} = 100 \mu m$$



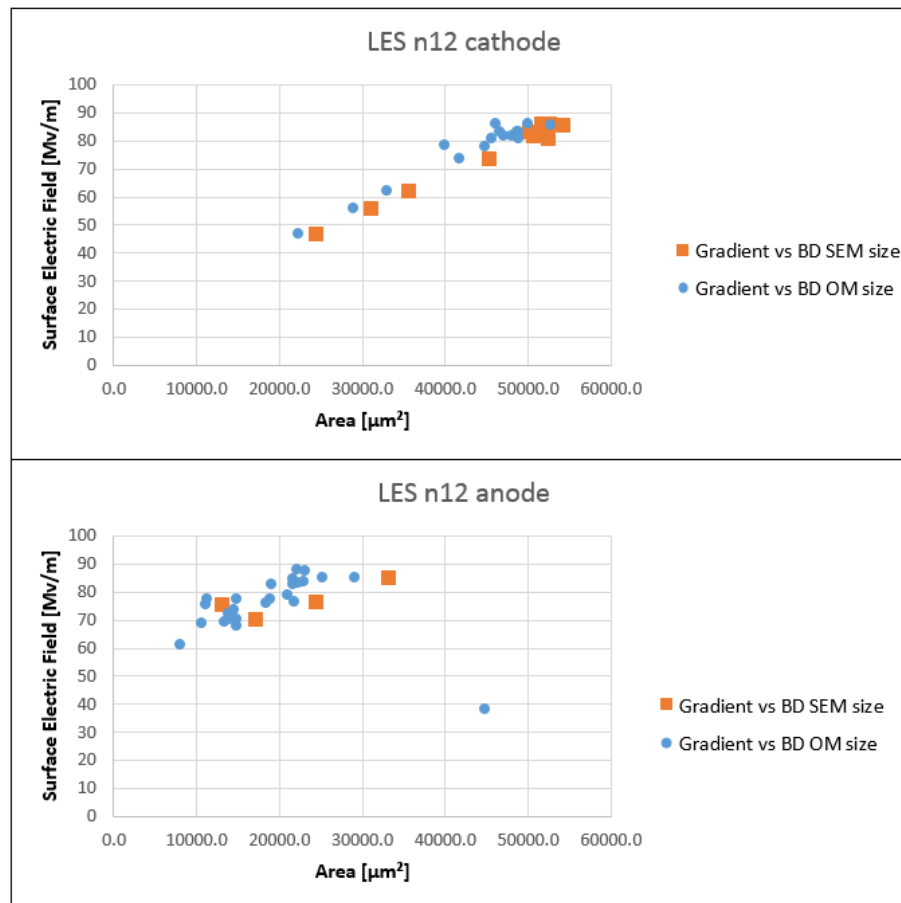
# Crater area as a function of pulsing conditioning



## Large Electrode System (LES)



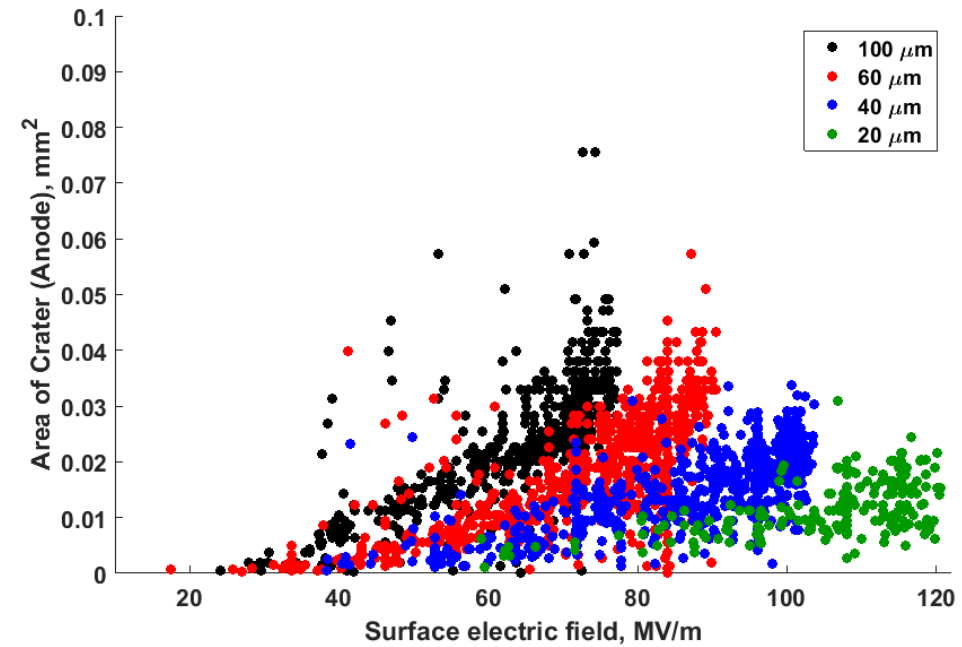
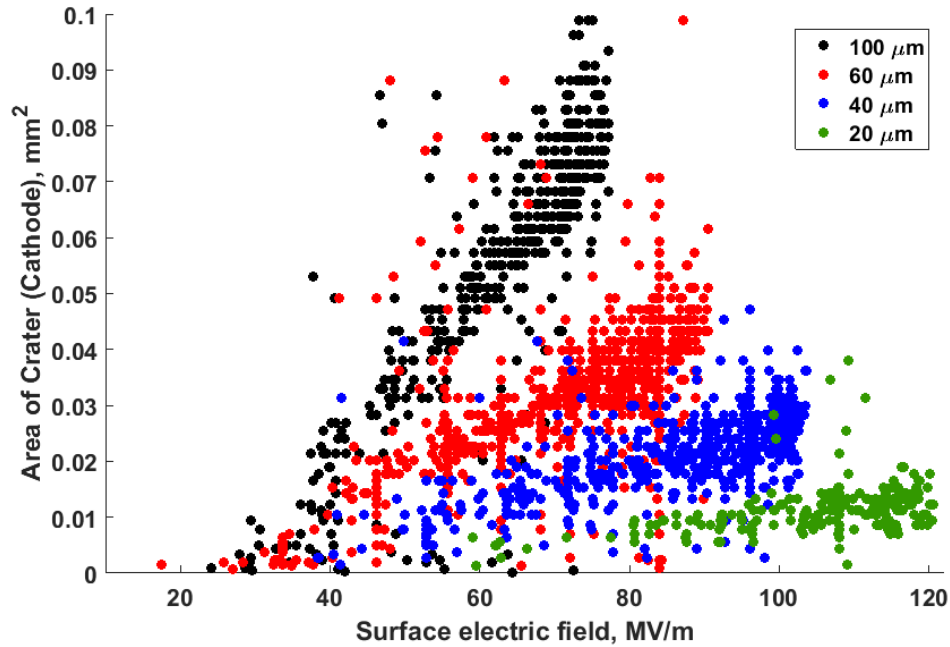
- Preliminary results show that crater size increase with surface electric field



**Enrique Rodríguez Castro,  
MeVArc 2018**

[https://indico.cern.ch/event/680402/contributions/2976643/attachments/1654803/2648883/MeVArc2018\\_ERCvIndico.pdf](https://indico.cern.ch/event/680402/contributions/2976643/attachments/1654803/2648883/MeVArc2018_ERCvIndico.pdf)

# Cathode/Anode craters



Gap, μm	Average area of the craters, mm <sup>2</sup>			Average diameter of the craters, μm		
	Cathode	Anode	Ratio C/A	Cathode	Anode	Ratio C/A
100	0.055	0.023	2.39	255	164	1.55
60	0.034	0.02	1.7	204	152	1.34
40	0.022	0.016	1.38	165	137	1.2
20	0.011	0.012	0.92	118	119	0.99

# Cathode/Anode craters

$$Energy = \frac{1}{2} \epsilon_0 E^2 A d + \int_{\tau_{BD}}^{\tau_{BD} + \Delta\tau} I(t)V(t) dt$$

$E$  – surface electric field,  $A$  – electrode area,  
 $d$  – gap distance,  $\epsilon_0$  – permittivity for vacuum.

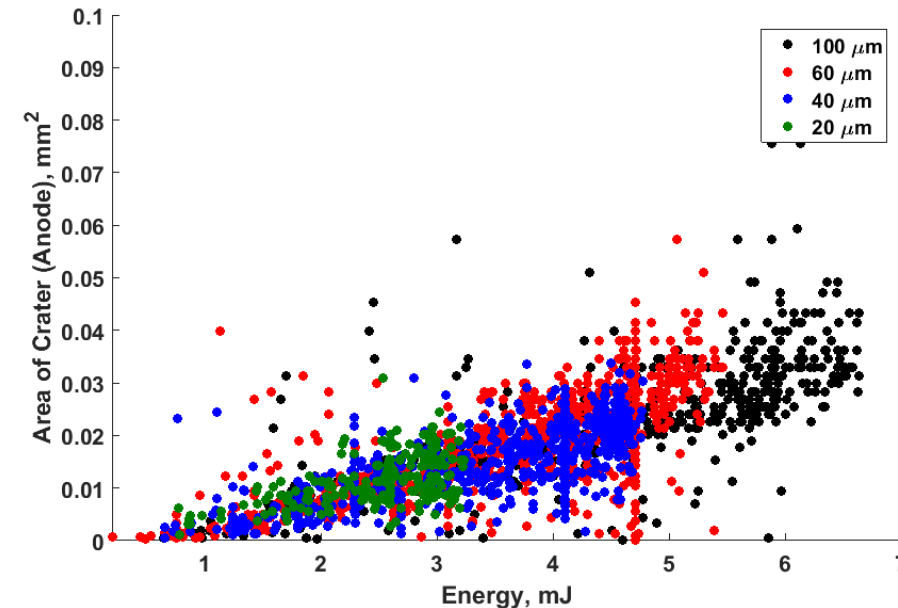
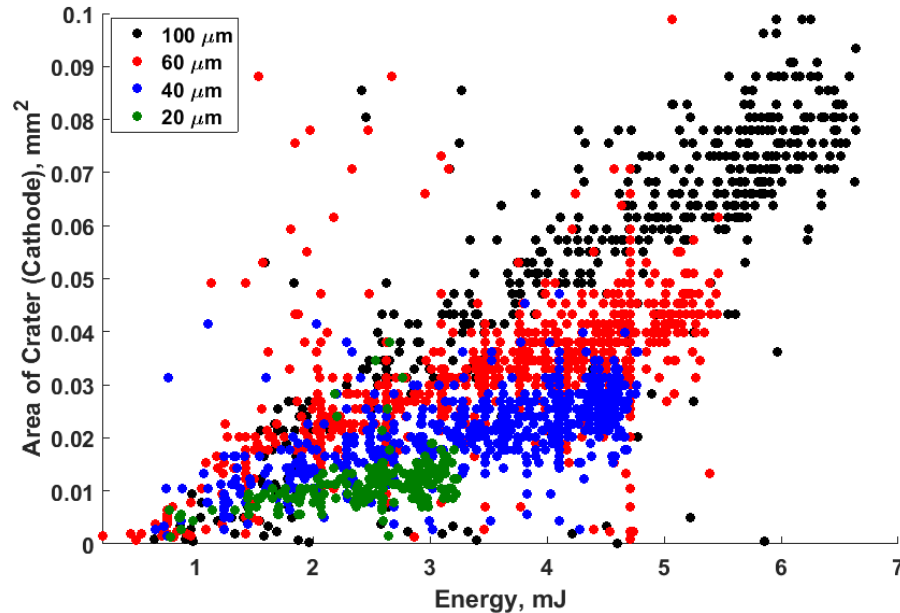
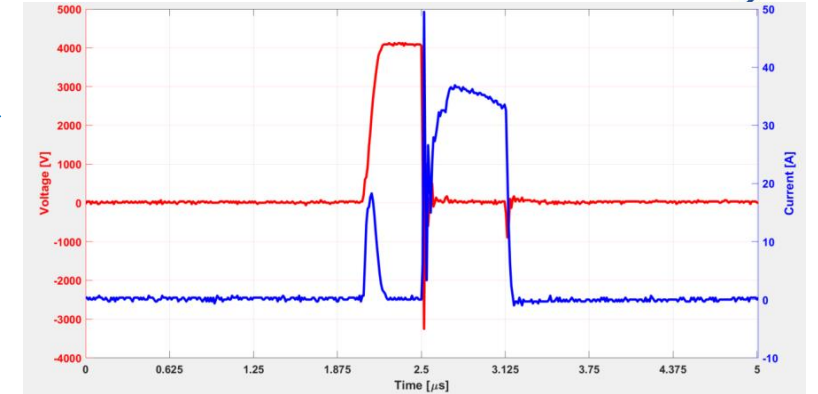
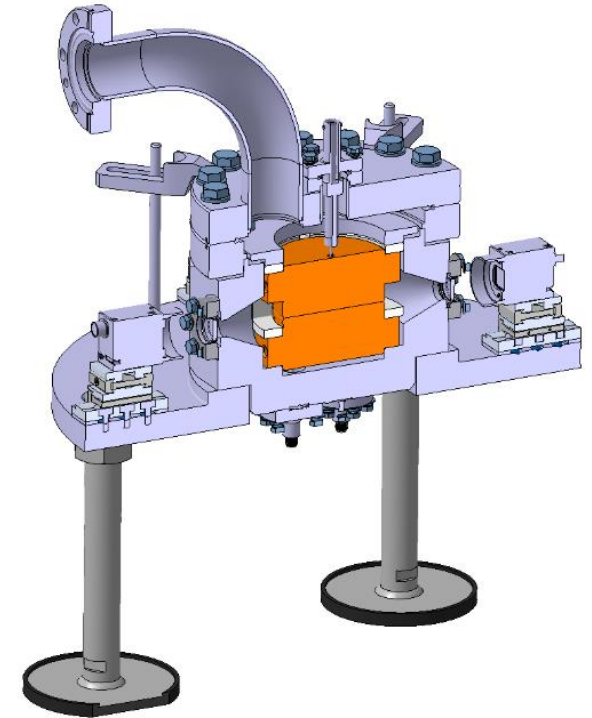


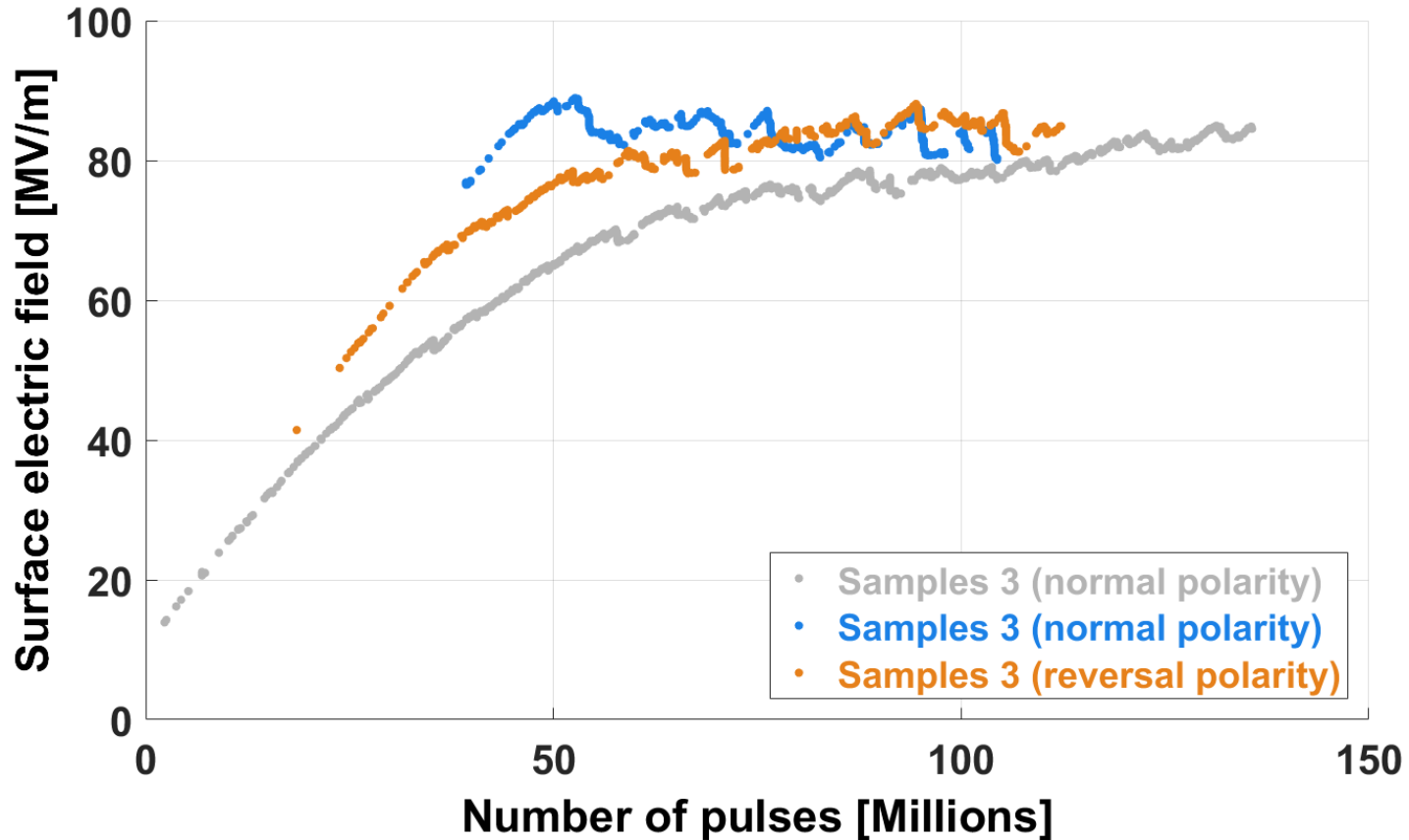
Fig. 20. The relation between crater area and energy (counted by using only first part of the formula).

## Do anode and cathode conditioning in the same time?

For changing the polarity, the connection of the HV is changing, i.e. high-voltage generator with **a positive polarity** is connected to the bottom electrode and the top electrode is grounded, hereinafter names as **a reversal polarity**. The test is done *in situ*, without venting and re-assembling the vacuum chamber.



# Polarity

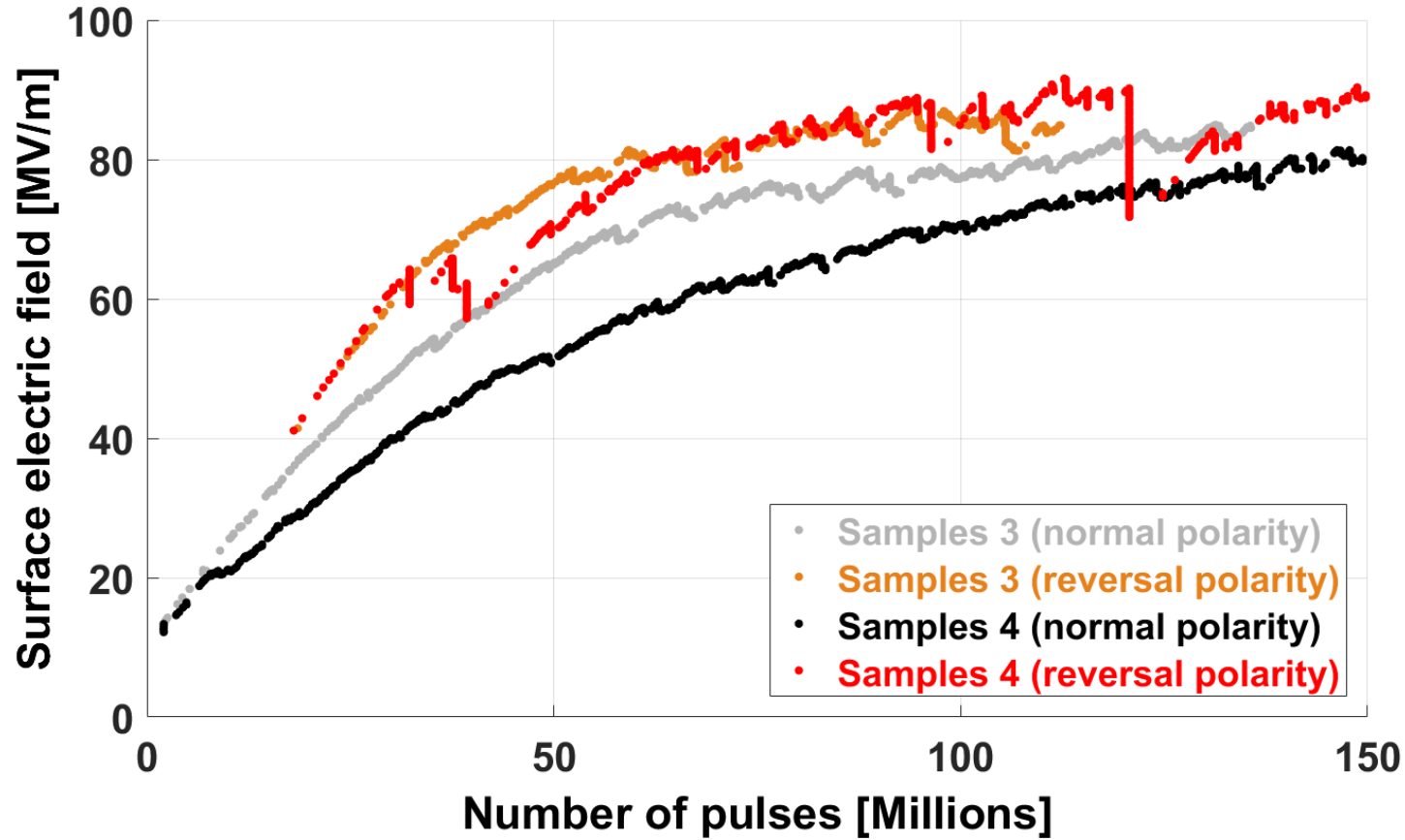


For changing the polarity, the connection of the HV is changing, i.e. high-voltage generator with a **positive polarity** is connected to the bottom electrode and the top electrode is grounded, hereinafter names as a **reversal polarity**. The test is done *in situ*, without venting and re-assembling the vacuum chamber.

Test is done with Soft Cu electrodes and spacer for 60  $\mu\text{m}$ .



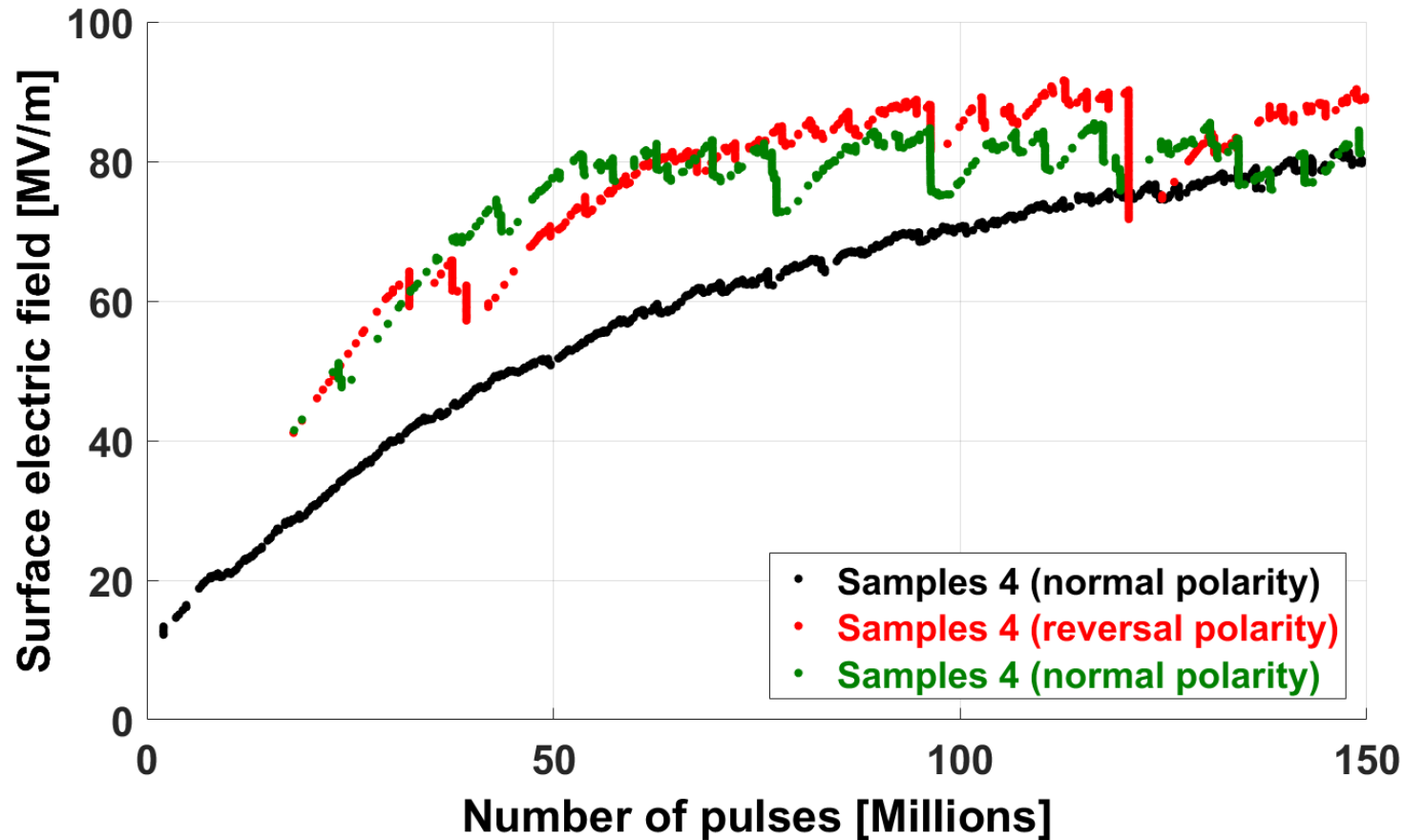
# Polarity



The initial conditioning curves with a normal polarity (**gray** and **black**) and the conditioning with reversal polarity (**orange** and **red**) for the Soft Cu electrodes tested with ceramic with 60  $\mu\text{m}$  gap.



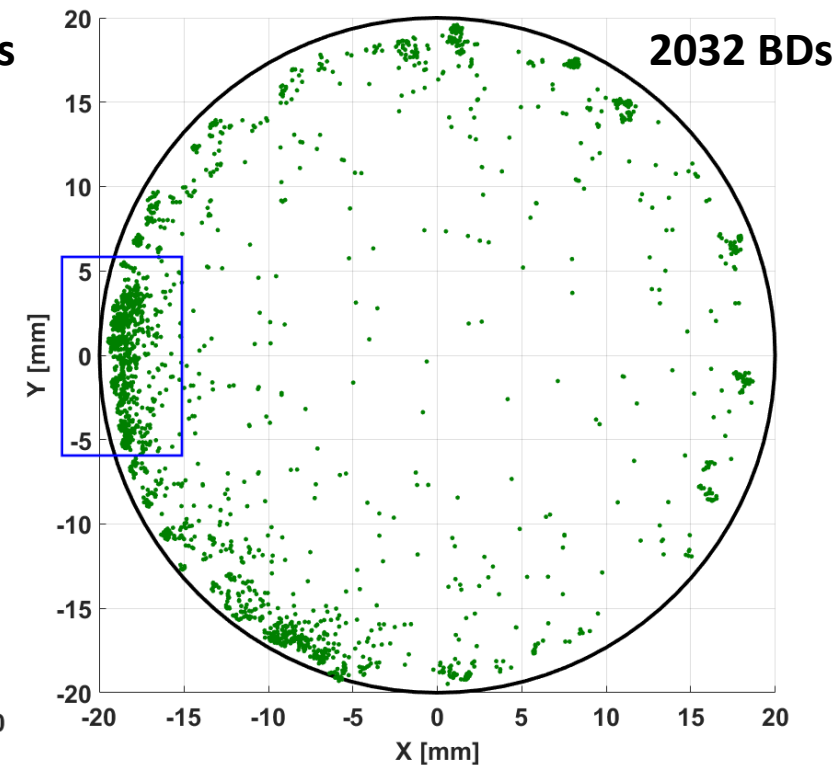
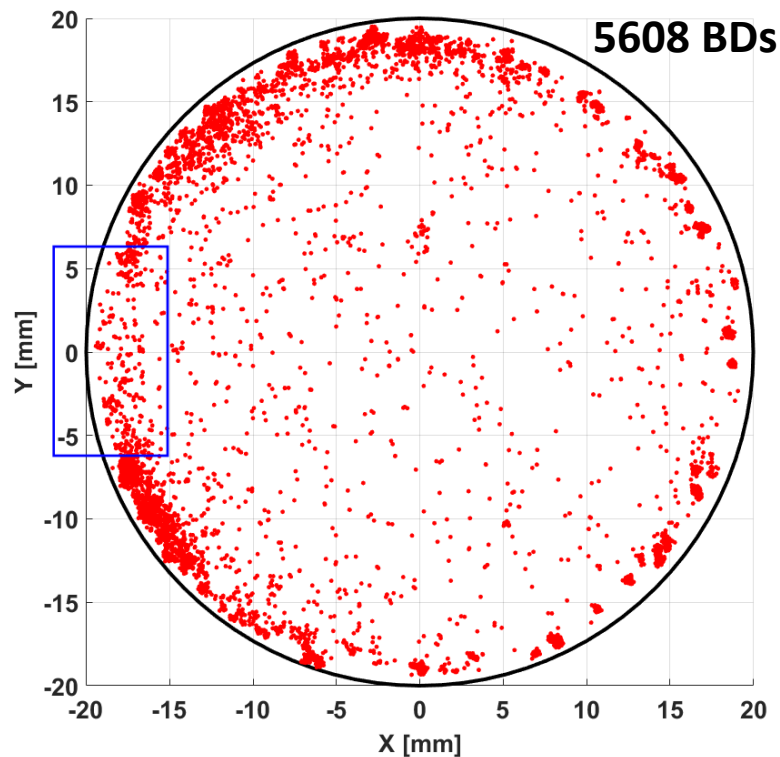
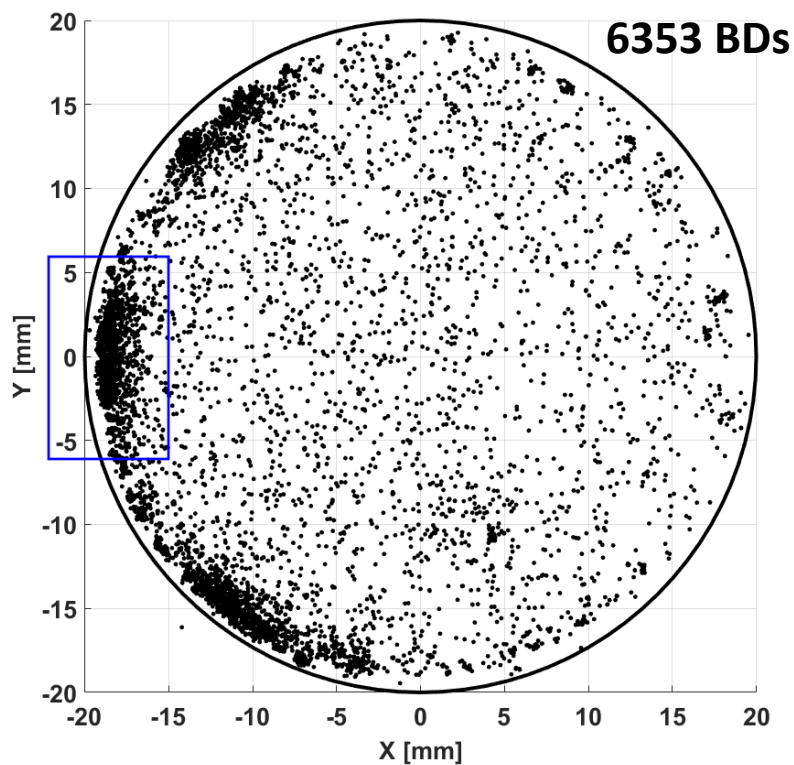
# Polarity



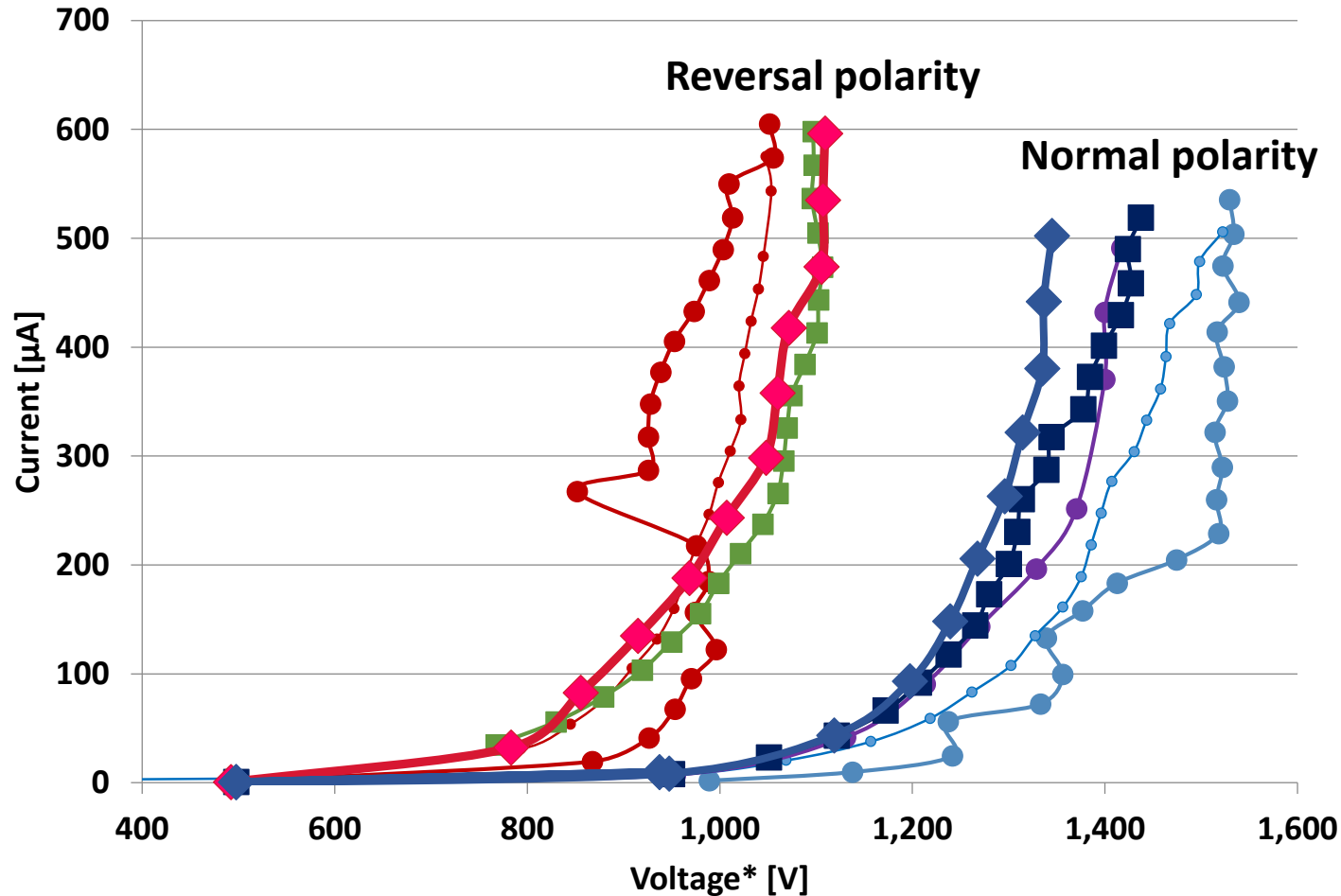
After returning to normal polarity, the reached during initial conditioning the surface electric field does not stay at the same level.



# BDs localisation with different polarity



BD localization for: **1** – normal polarity, **2** – reverse polarity, **3** – normal polarity



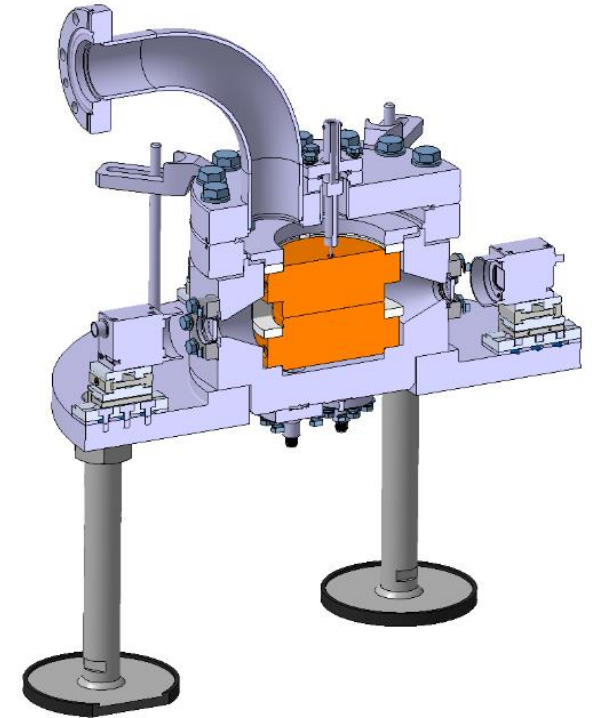
No	Direction	beta
1.	Normal Up	-----
2.	Normal Down	127
3.	Reversal Up	----
4.	Reversal Down	167
5.	Normal Up	130
6.	Reversal Up	273
7.	Normal Up	129
8.	Reversal Up	274
9.	Normal Up	116

Fig. 26. The absolute value of current vs voltage with different polarities. Measurements were done with **Cu electrodes** and spacer for 20  $\mu\text{m}$  gap.

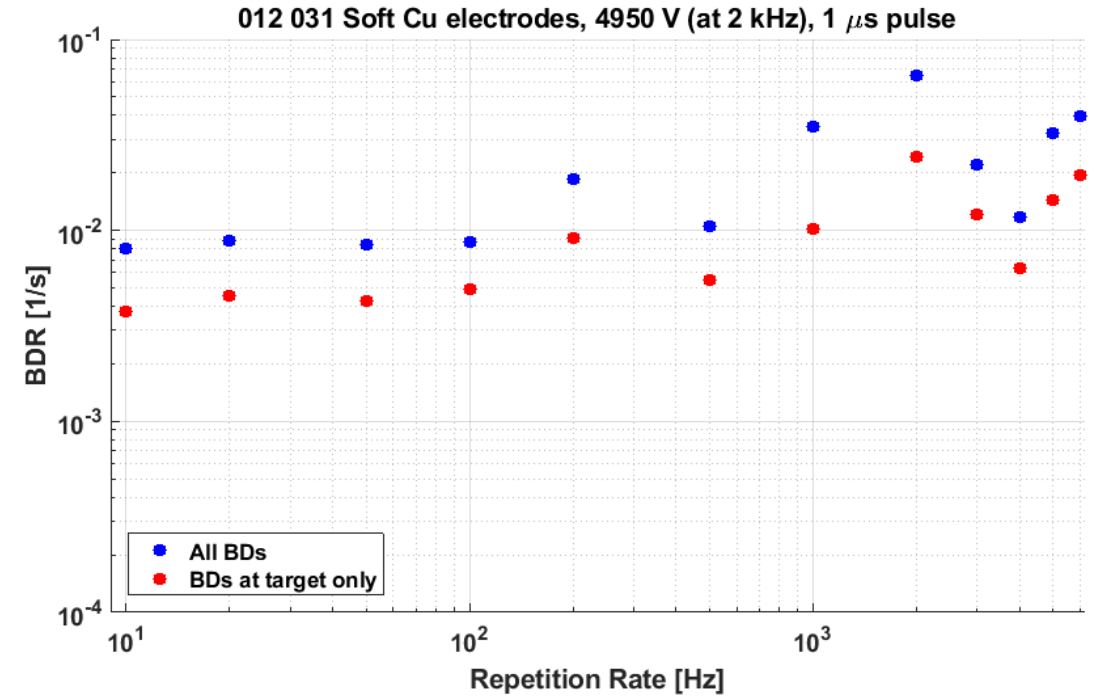
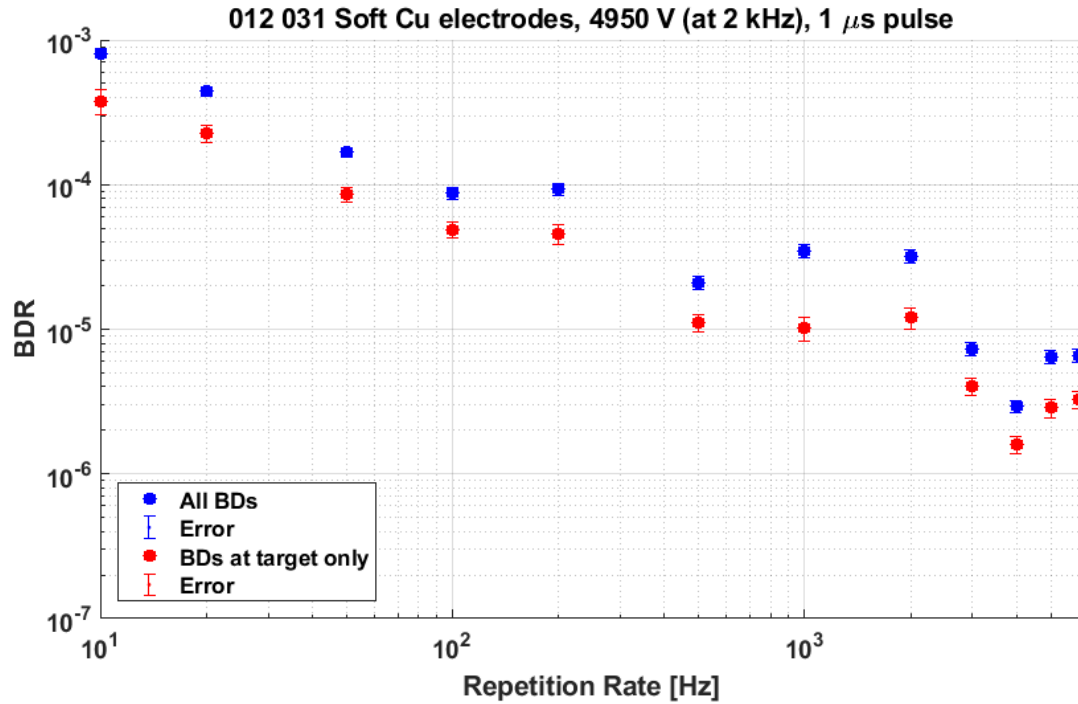
# Polarity

Do anode and cathode conditioning in the same time?

During conditioning of the cathode, the anode is also conditioned, but less effectively.



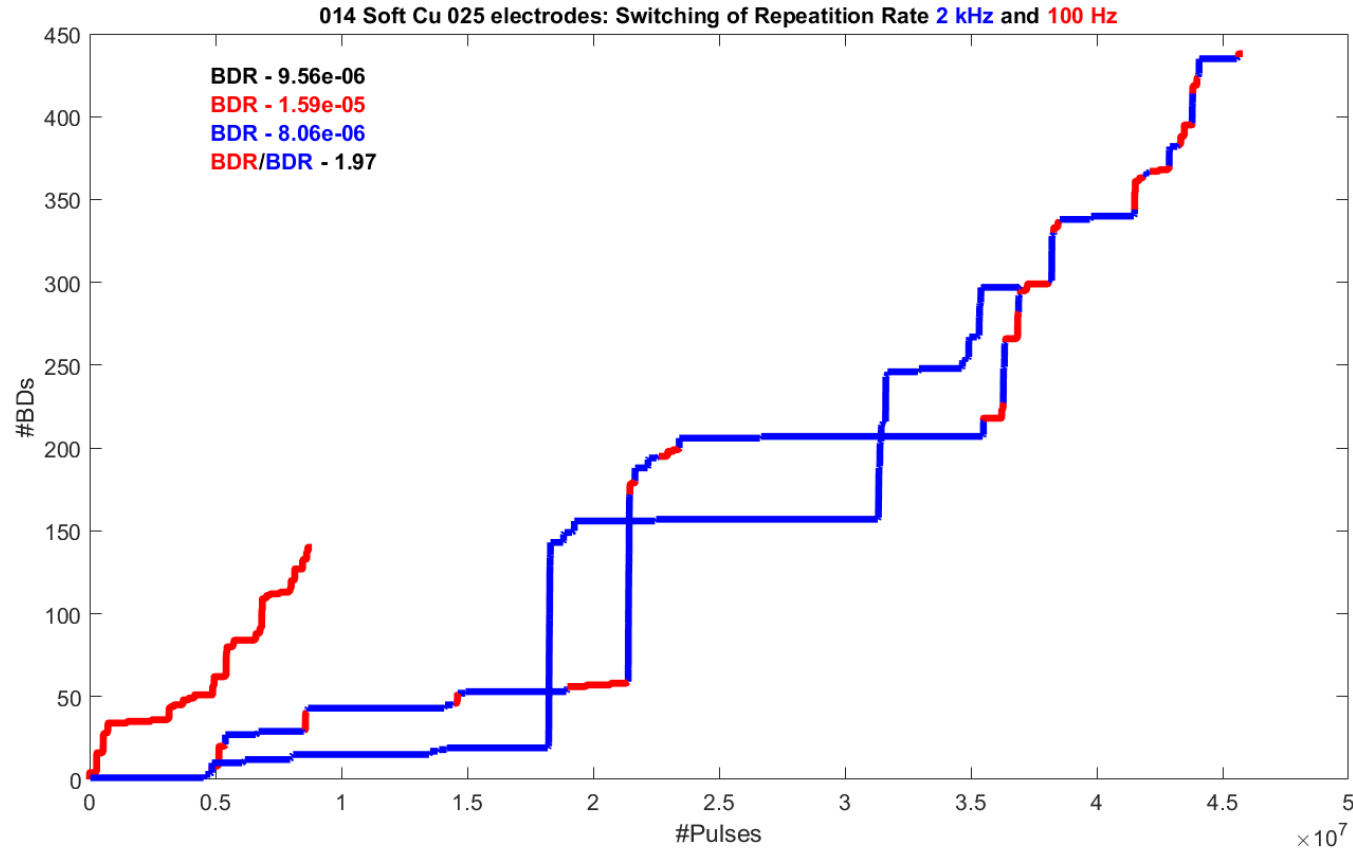
# BDR vs RepRate



The test was done with Soft Cu electrodes (without baking), the range of Rep Rate 10 Hz – 6 kHz (increasing order). Pressure during the test  $\sim 5E-8$  mbar.



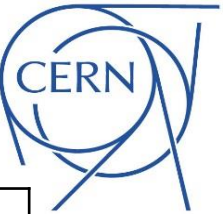
# Swap RepRates



Swap Rep Rate between  
**100 Hz** and **2 kHz** every  
3 BDs at Target voltage

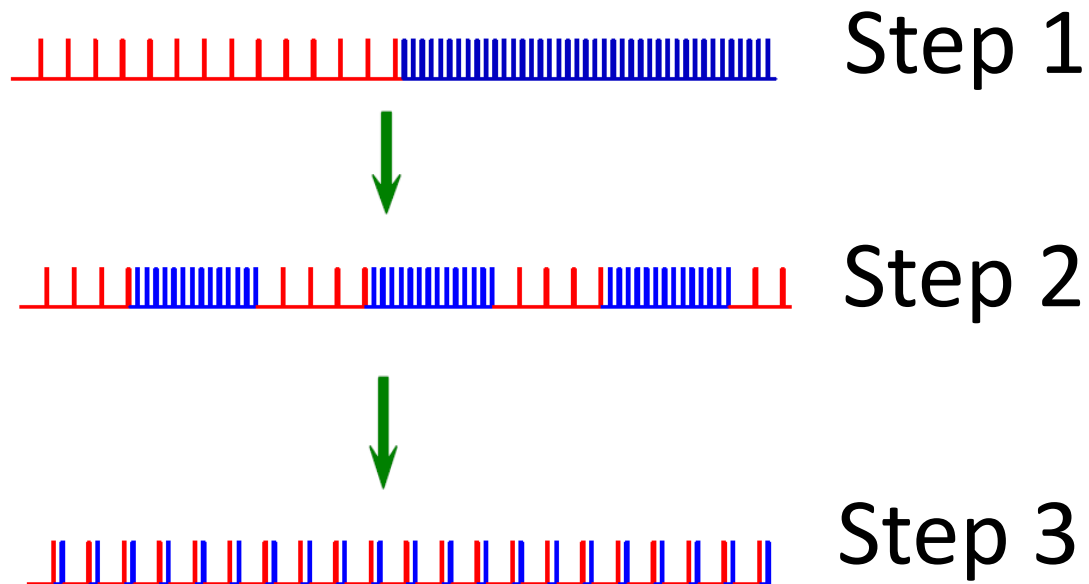


# Swap Rep Rates (100 Hz and 2 kHz)



Sample number	Material	Rep Rate F1/F2	V1/V2	#BDs1/ #BDs2	BDR1/ BDR2	Ratio (BDR1/BDR2)
005	SS CuAg		5220/5220	112/16	1.12E-5/1.59E-6	7.04
005	SS CuAg		5220/5220	60/8	5.98E-6/7.99E-7	7.48
006	Nb		6000/6000	198/201	3.99E-5/3.43E-6	11.63
006	Nb		6000/6000	255/224	2.66E-5/3.59E-6	7.41
007	Hard Cu	100/2000	4520/4500	145/138	2.96E-5/1.89E-5	1.57
007	Hard Cu		4440/4460	87/96	1.63E-5/1.11E-5	1.47
007	Hard Cu		4380/4400	103/102	6.34E-6/3.34E-6	1.9
008	Soft Cu		4780/4800	195/156	1.99E-4/6.56E-5	3.03
008	Soft Cu		4600/4620	130/152	2.28E-5/6.9E-6	3.3
008	Soft Cu		4510/4530	77/83	1.96E-5/7.65E-6	2.56
008	Soft Cu		4450/4570	89/90	1.28E-5/7.89E-6	1.62
008	Soft Cu		4400/4420	145/133	1.38E-5/1.29E-6	10.7
004	SS and Cu		3760/3780	59/137	2.11E-6/1.12E-6	1.88

# Rep Rate/Pause effect



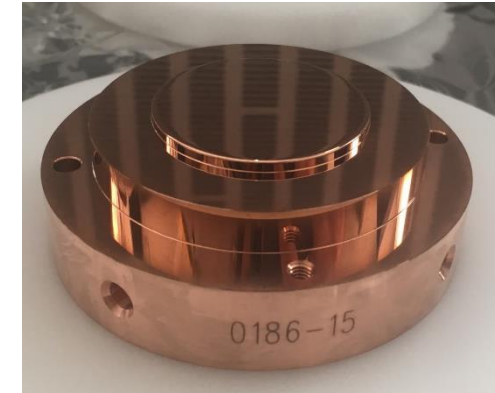
Results for **009 Soft Cu** electrodes, 1  $\mu$ s pulse width.

E field [MV/m]	Rep Rate, Hz	Pause before pulse, ms	BDs	BDR	<b>BDR/BDR</b>
62	100	10	197	2.30E-05	<b>1.63</b>
	2000	0.5	121	1.41E-05	
61	100	10	116	9.30E-06	<b>1.14</b>
	2000	0.5	102	8.18E-06	
62	100	10	57	8.05E-06	<b>1.46</b>
	2000	0.5	39	5.51E-06	

**Conclusion: Pause between high-voltage pulse matters!**

No.	Material	Information
1.	Hard Cu	OFE copper, as-machined using fly-cut and diamond turning, roughness 30 nm.
2.	Cu	OFE copper, as-machined using fly-cut and diamond turning, heated up to 800°C in hydrogen atmosphere.
3.	Soft Cu	OFE copper, as-machined using fly-cut and diamond turning, heated up to 1040°C in hydrogen atmosphere.
4.	Ni	99.5% Ni, roughness is around 400 nm.
5.	Inox	Steel alloy, 16.73% Cr, 10.13% Ni, 2.04% Mo, 1.54% Mn and 1.51% others.
6.	Co	99.9% Co, roughness is around 800 nm.

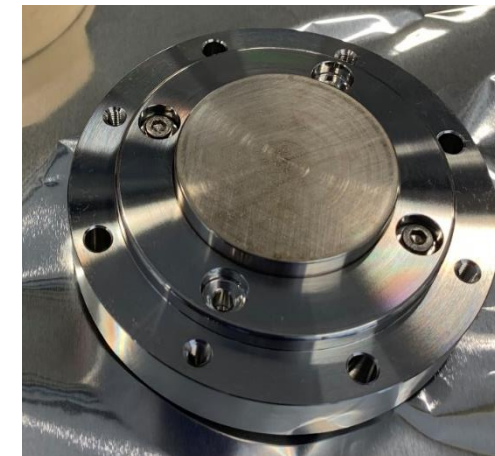
**Cu**



**Ni**



**Inox**



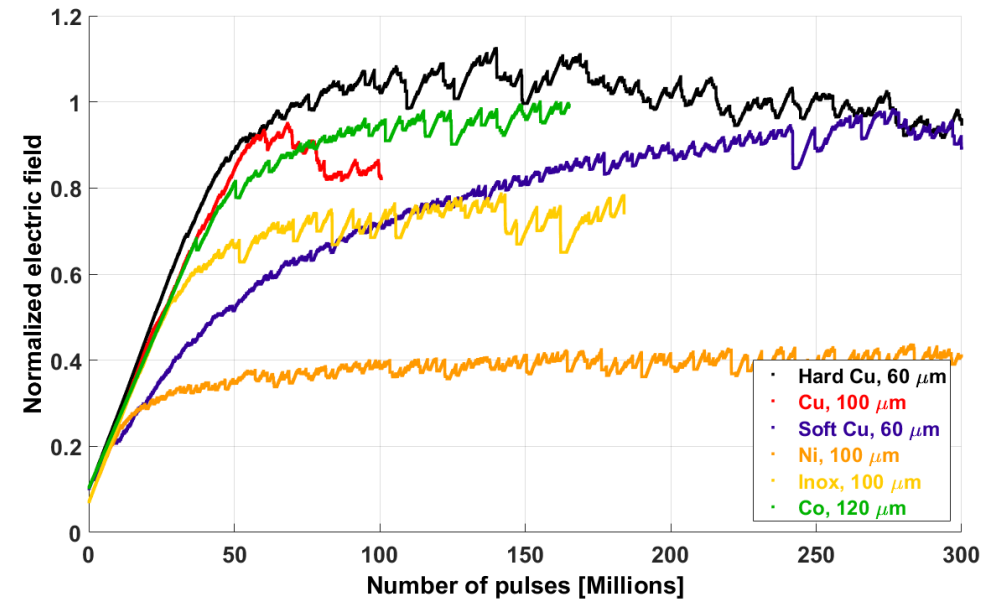
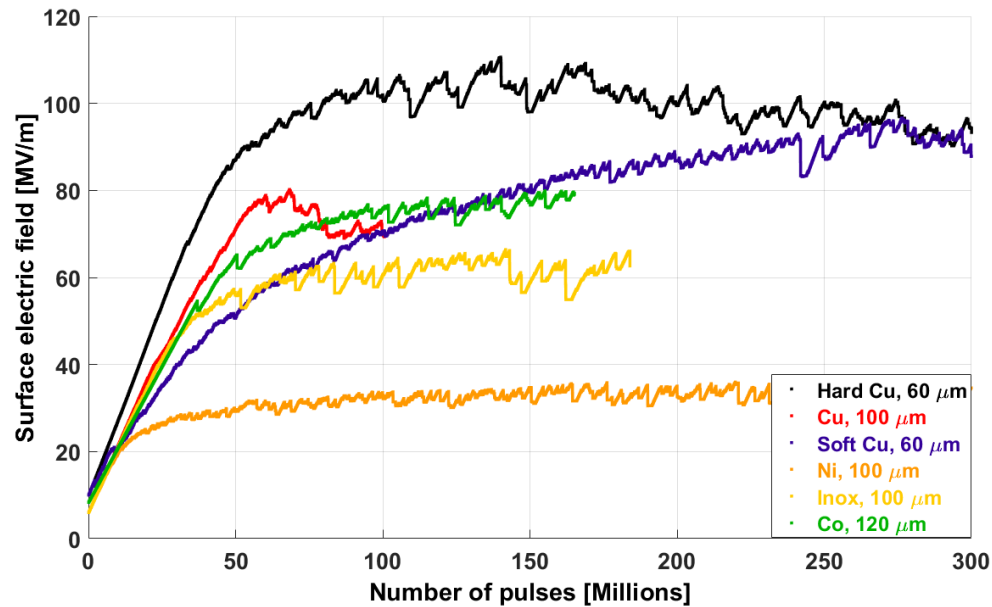
**Co**







# Conditioning behavior for various materials



$$E_{surf} = \frac{V}{d}$$

$$E_{norm} = \left( \frac{V}{V_{max}} \right) \times \left( \frac{d_{max}}{d} \right)^{0.7}$$

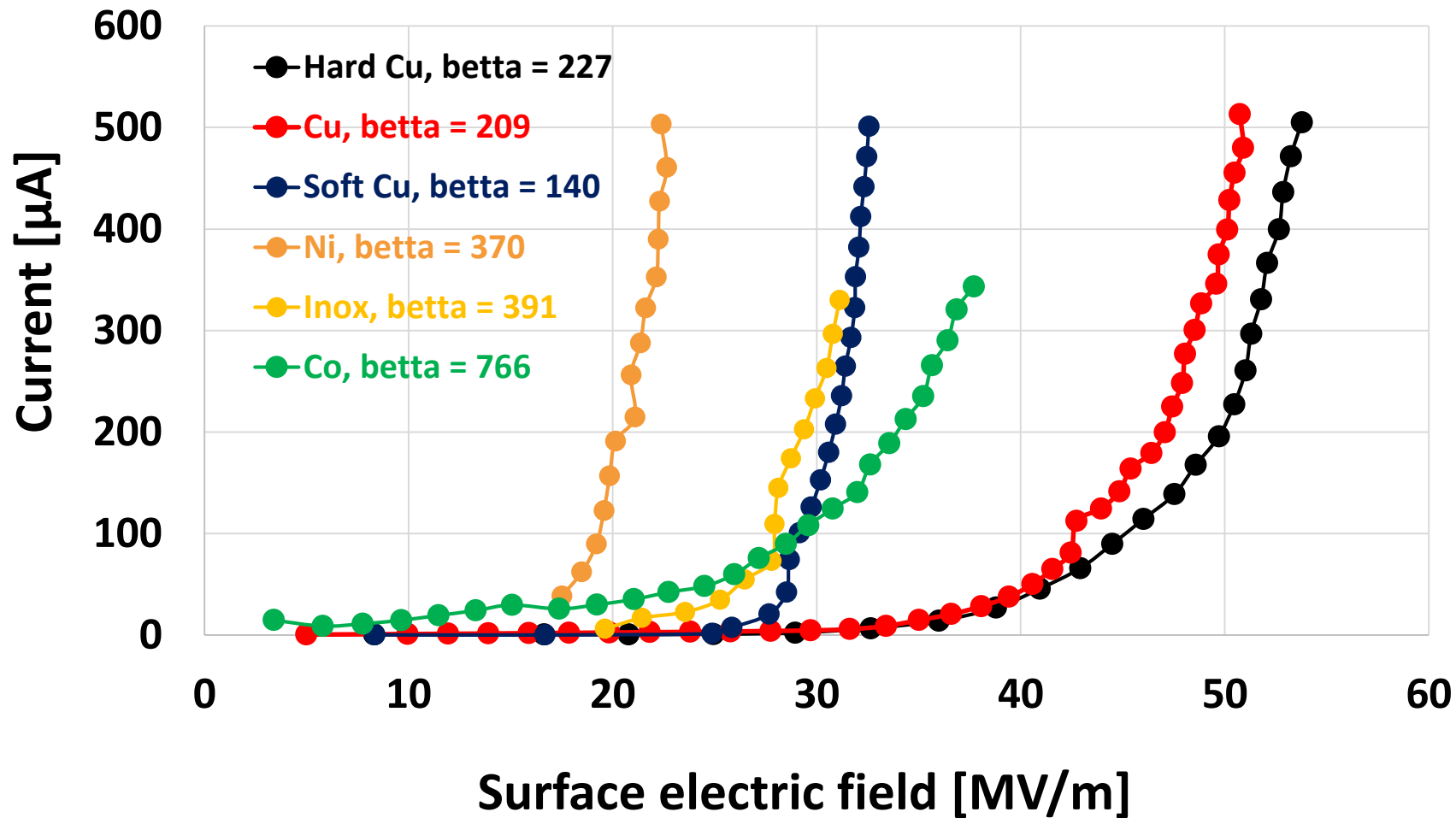


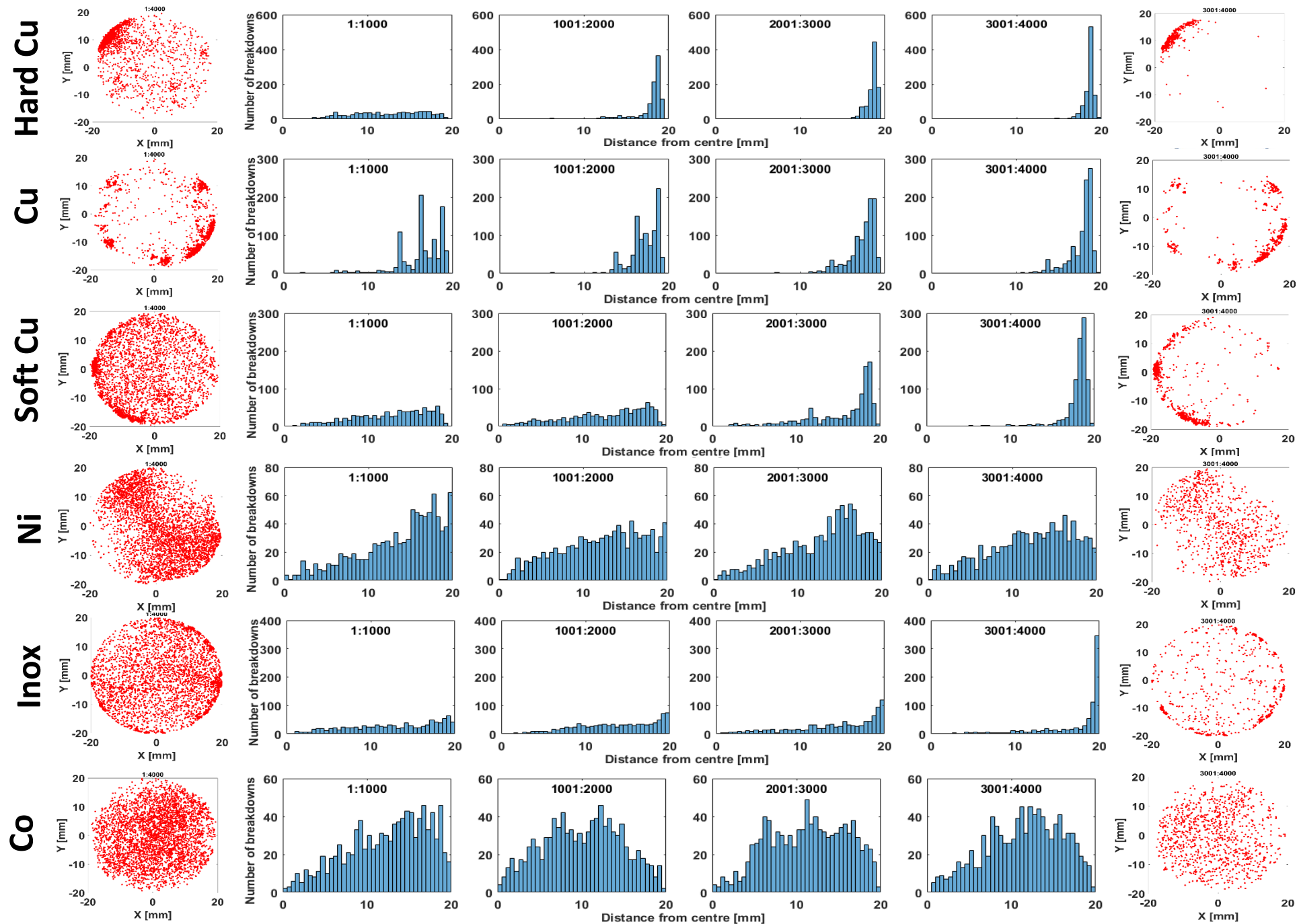
Fig. Current vs Surface electric field

$$E_{surf} = \frac{V}{d}$$

for the various materials made after initial conditioning.



Fig. 35. Evolution of first 4000 break-downs distribution for different materials.



# Material comparison

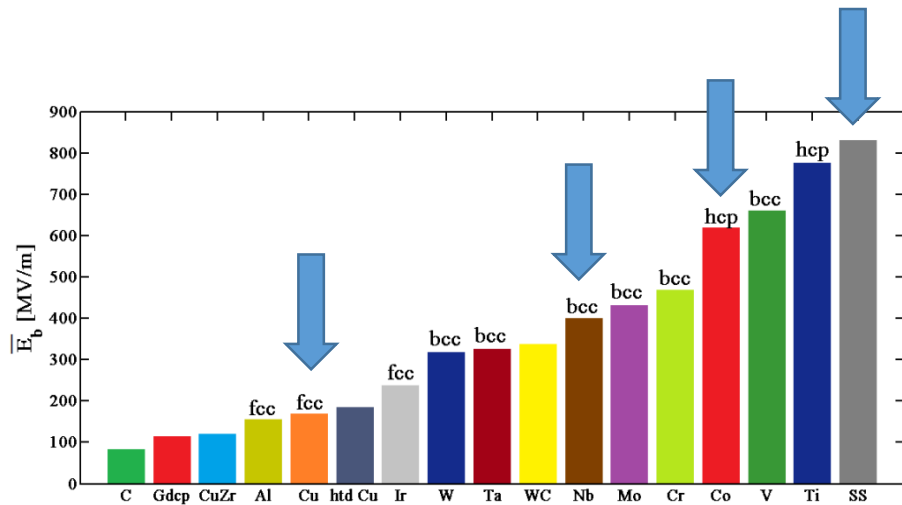


Figure 5: Average breakdown fields after conditioning of iridium shown with that of the materials previously tested in [1]. For pure metals, their crystal structures are indicated (fcc = face-centred cubic, bcc = body-centred cubic, hcp = hexagonal closest packing) on the top.

Fig. 36.1. Results from the pulsed dc system with tip plane geometry of electrodes (“DC spark system”).

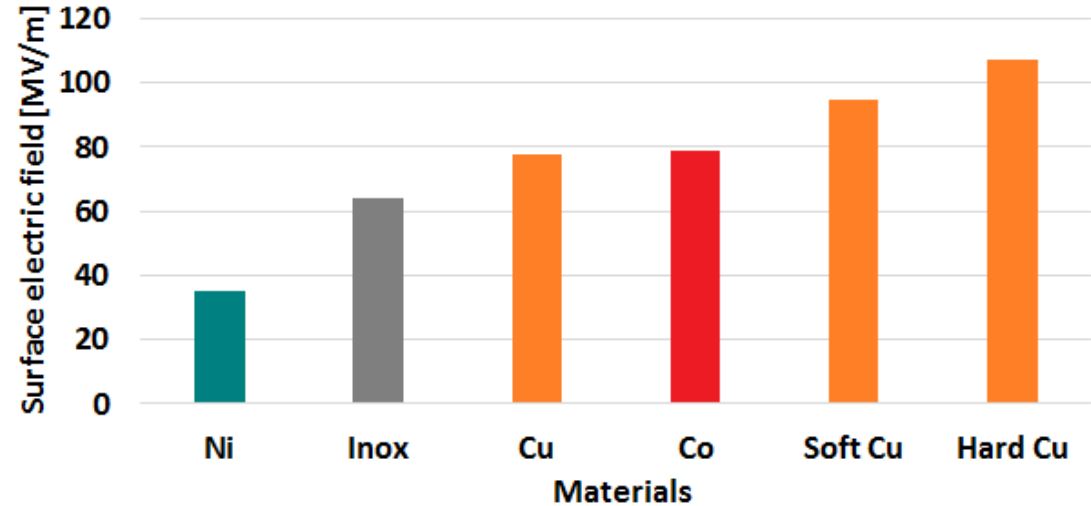
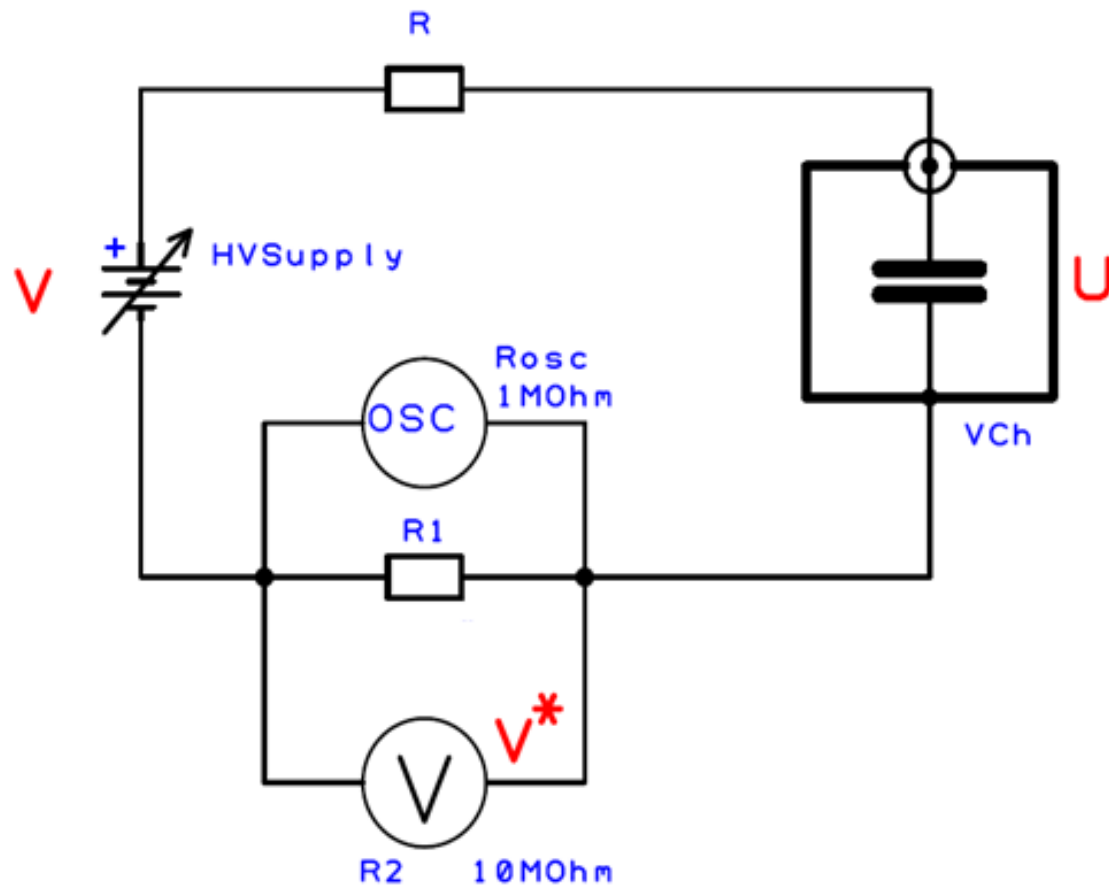


Fig. 36.2. Results from the pulsed dc system with 2 plane electrodes (Large Electrodes System).

# Field emission measurement (static)



Voltage applied to the LES  
(anode-cathode voltage):

$$U = V - I \times R \quad (1),$$

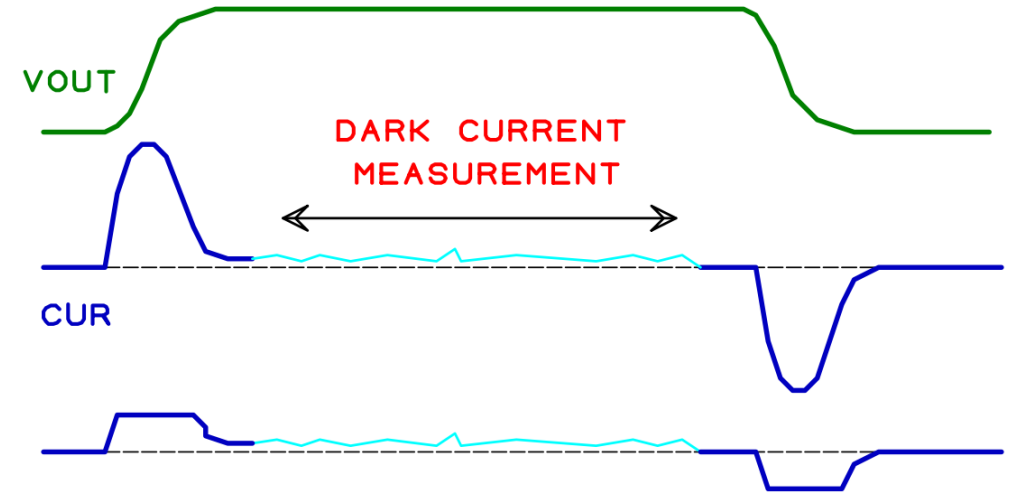
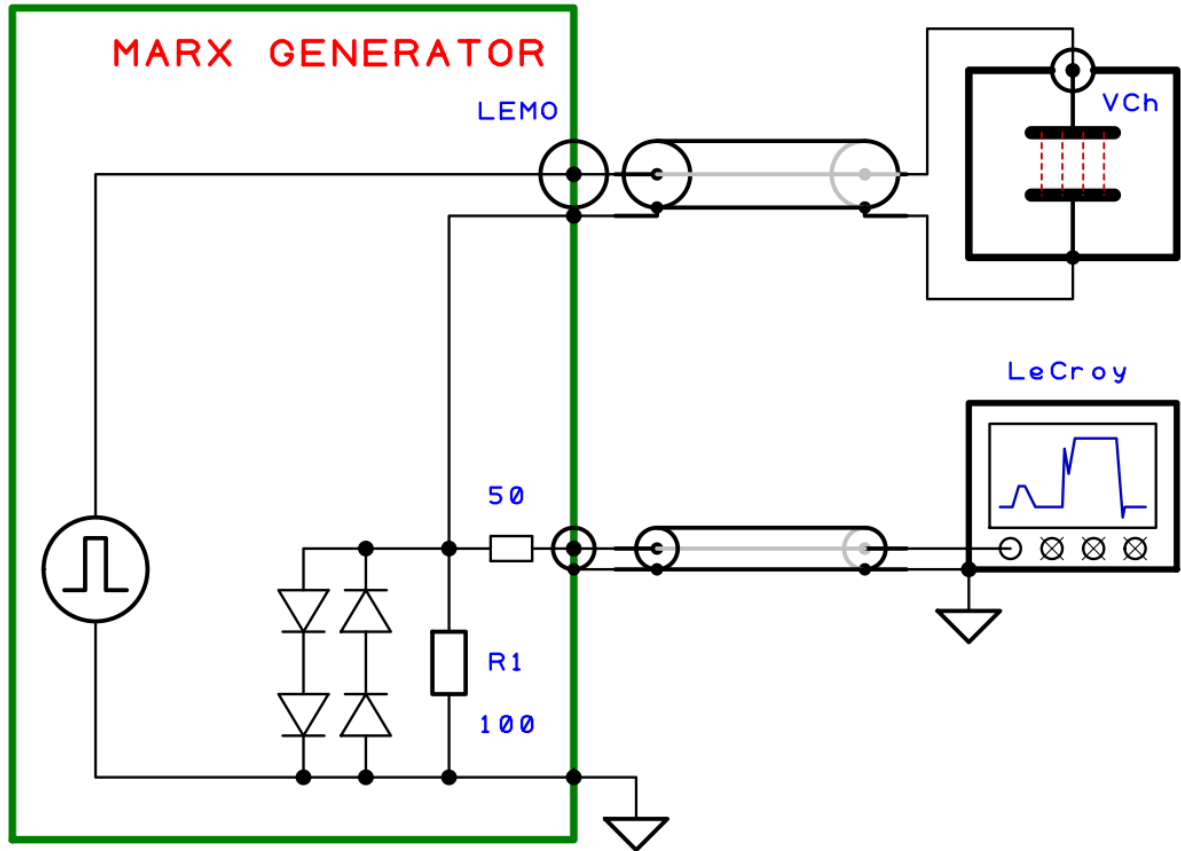
$V$  - voltage at power supply,  
 $R = 6.39 \text{ MOhm}$ .

$I = \frac{V^*}{R^*}$ ,  $V^*$  - voltage at the multimeter.

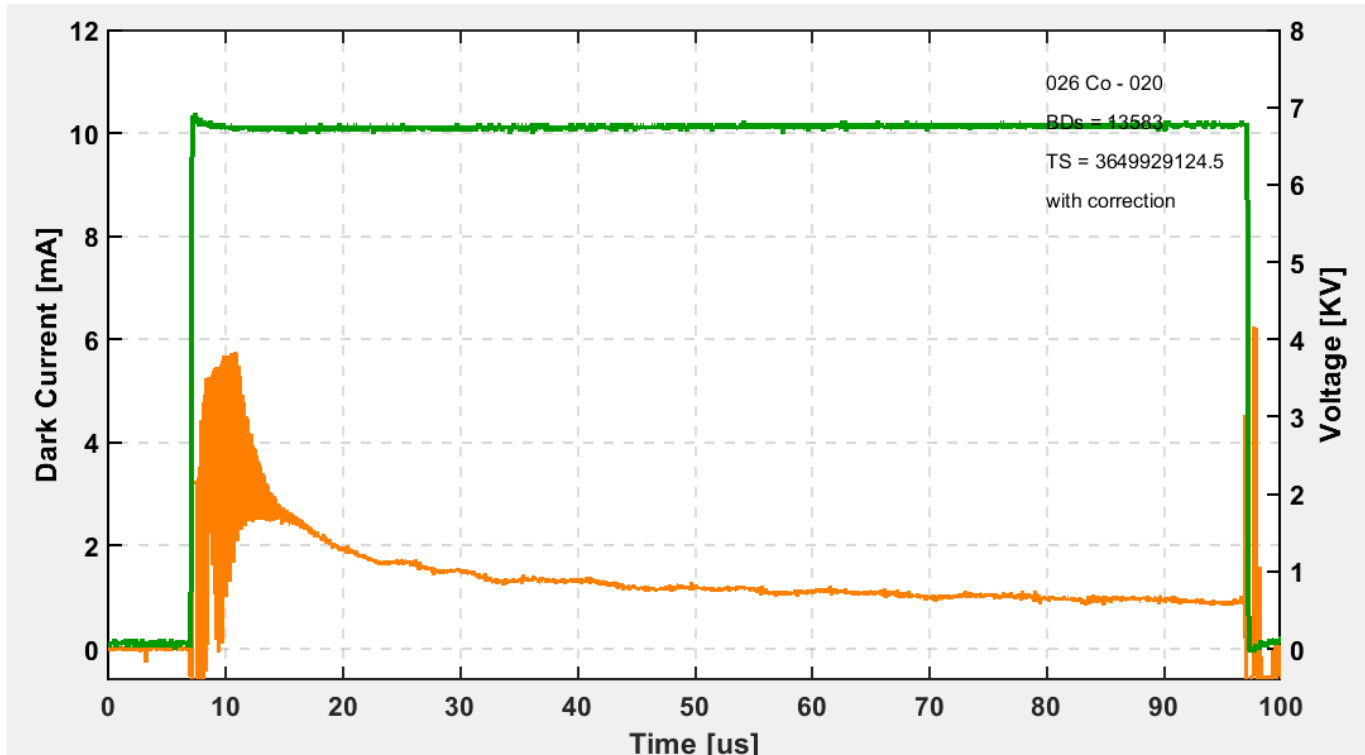
$$\frac{1}{R^*} = \frac{1}{R_{osc}} + \frac{1}{R_1} + \frac{1}{R_2}, \quad R_1 = 100 \text{ kOhm} \Rightarrow$$

$$R^* \approx 90.1 \text{ kOhm}$$

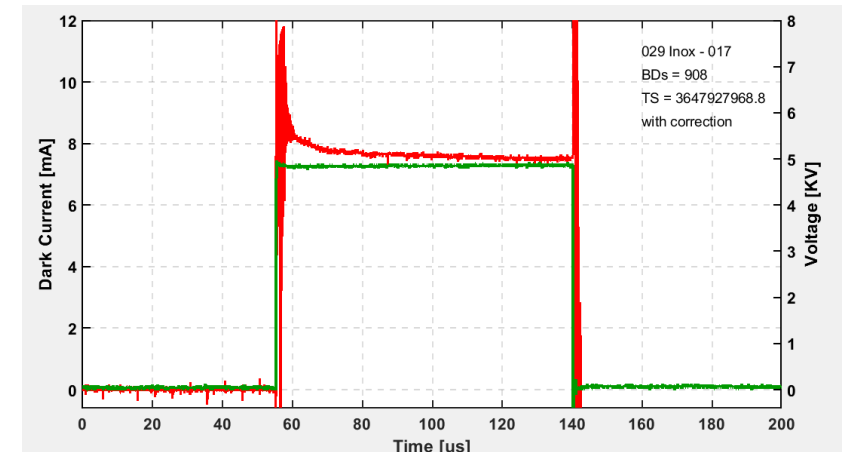
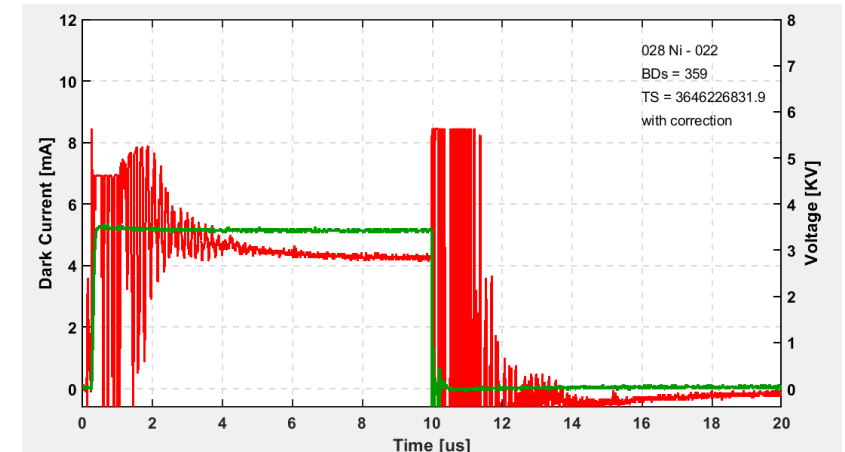
# Field emission measurement (dynamic, i.e. over pulsing)



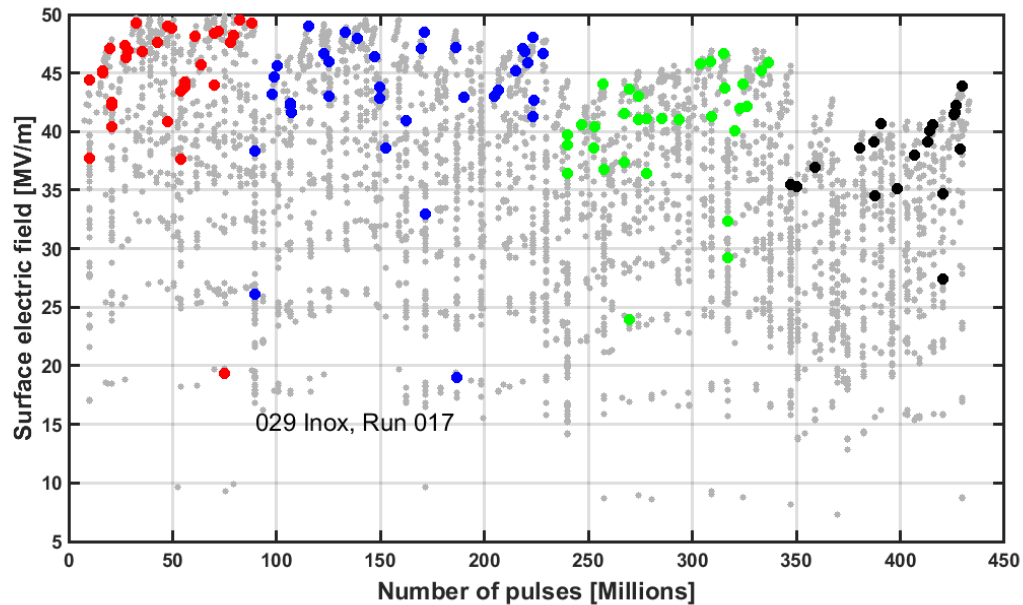
# Field emission measurement (dynamic, i.e. over pulsing)



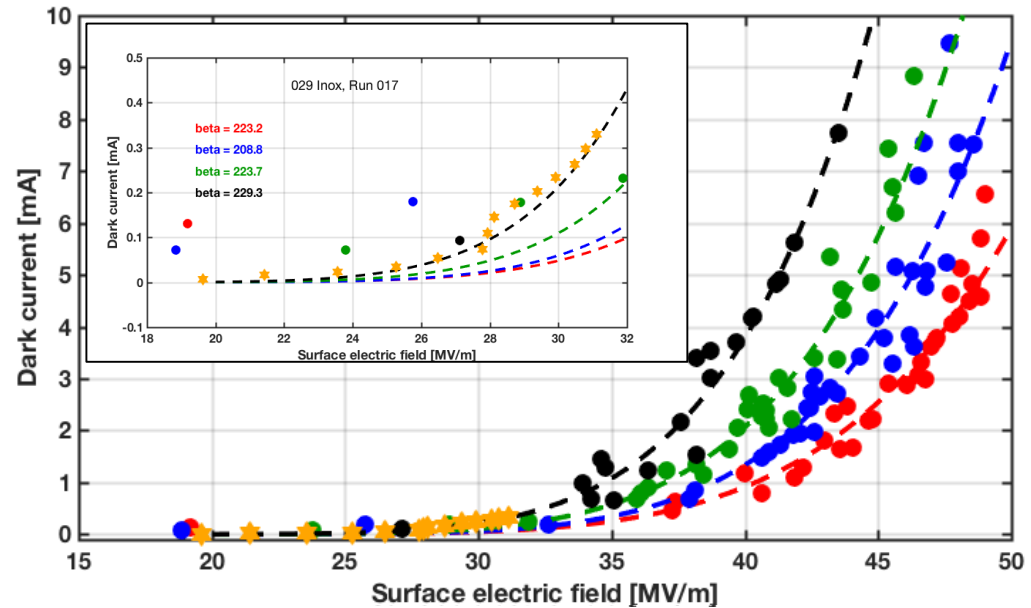
Example of waveform from the dynamic field emission measurement for Cobalt electrodes taken with 90 us pulse width and 6744 V. The next breakdown occur with 7155 V).



# Field emission measurement (static vs dynamic)



Conditioning using feedback algorithm for the Inox electrodes tested with a spacer for  $100\ \mu\text{m}$  gap with  $90\ \mu\text{s}$  pulse width.

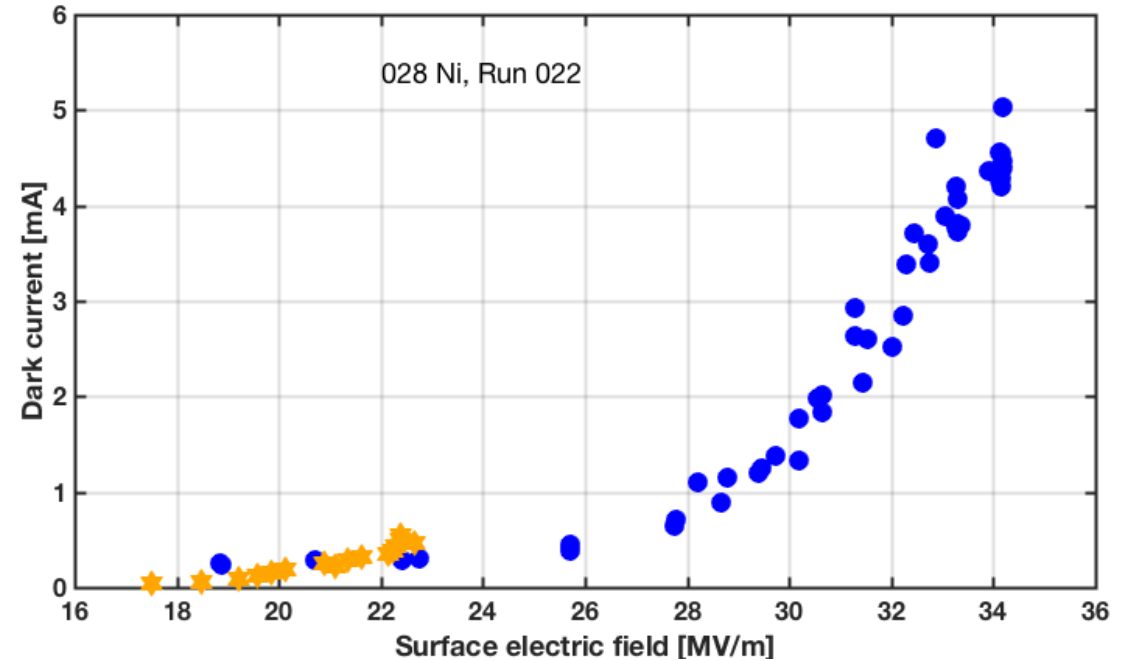
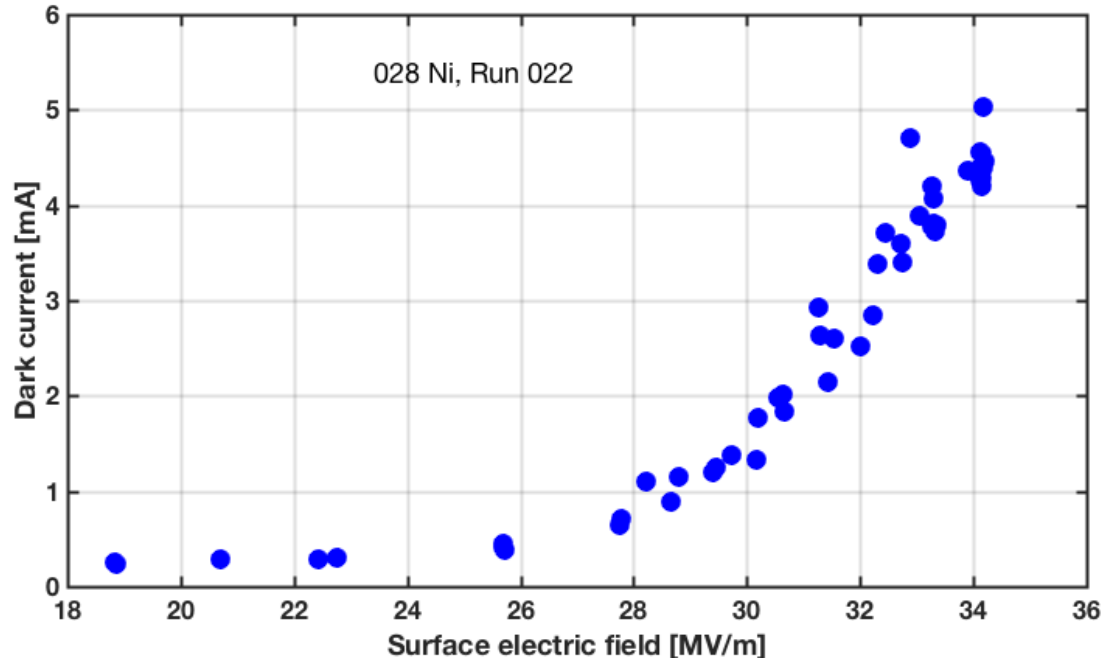


Field emission measurement for Inox electrodes: comparison static with dynamics measurements. (orange – static field emission measurements)





# Field emission measurement (static vs dynamic)



The current voltage diagram for the Ni electrodes: **blue** – during dynamic FE measurements, **orange** – during static FE measurements.



# Future plans



- Optical spectroscopy of field emission (Ruth's poster).
- Dark current measurements (Jan's poster).
- Swap polarities each pulse.
- To study the effect of rise and fall times to BDR.
- Compact design of electrodes.



Engineering

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## Optical Spectroscopy in the Pulsed DC Large Electrode System at CERN

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<sup>2</sup>Cockcroft Institute of Accelerator Science and Technology, Daresbury, United Kingdom

<sup>3</sup>CERN, Geneva, Switzerland



## DARK CURRENT FLUCTUATIONS IN HIGH GRADIENT RF AND PULSED DC EXPERIMENTS

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<sup>1</sup>John Adams Institute, Department of Physics, University of Oxford, Oxford, United Kingdom

<sup>2</sup>European Organisation for Nuclear Research (CERN), Geneva, Switzerland



## Recent progress at pulsed dc systems at CERN

Iaroslava Profatlova<sup>1</sup>, Ruth Peacock<sup>1,2</sup>, Enrique Rodriguez Castro<sup>1</sup>, Sergio Calatroni<sup>1</sup>, Walter Wuensch<sup>1</sup>

<sup>1</sup>CERN, Geneva, Switzerland, <sup>2</sup>Lancaster University, United Kingdom





# Thank you!

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[iaroslava.profatilova@gmail.com](mailto:iaroslava.profatilova@gmail.com)



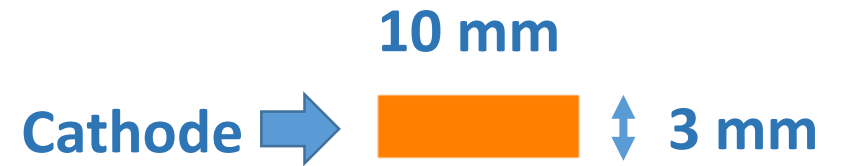
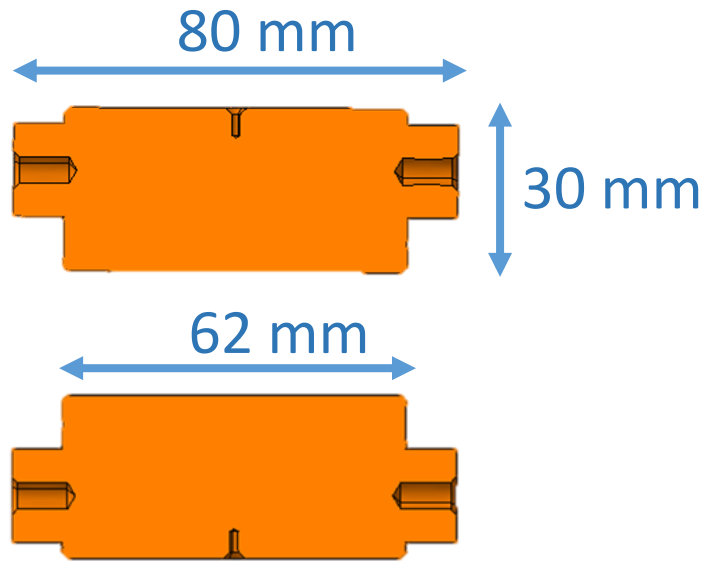
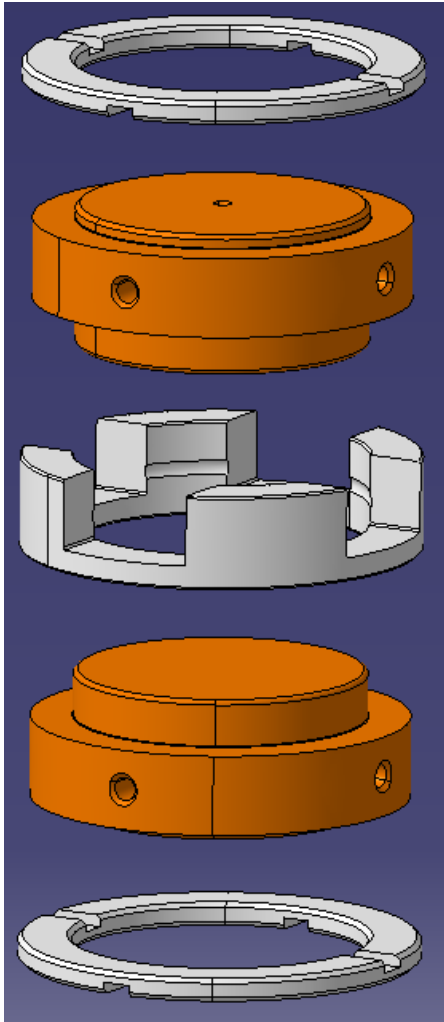
# Extra slides



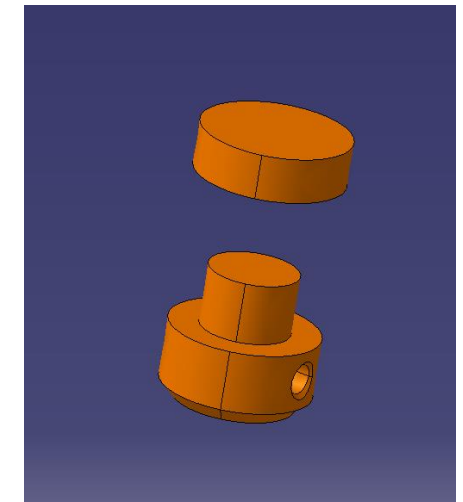
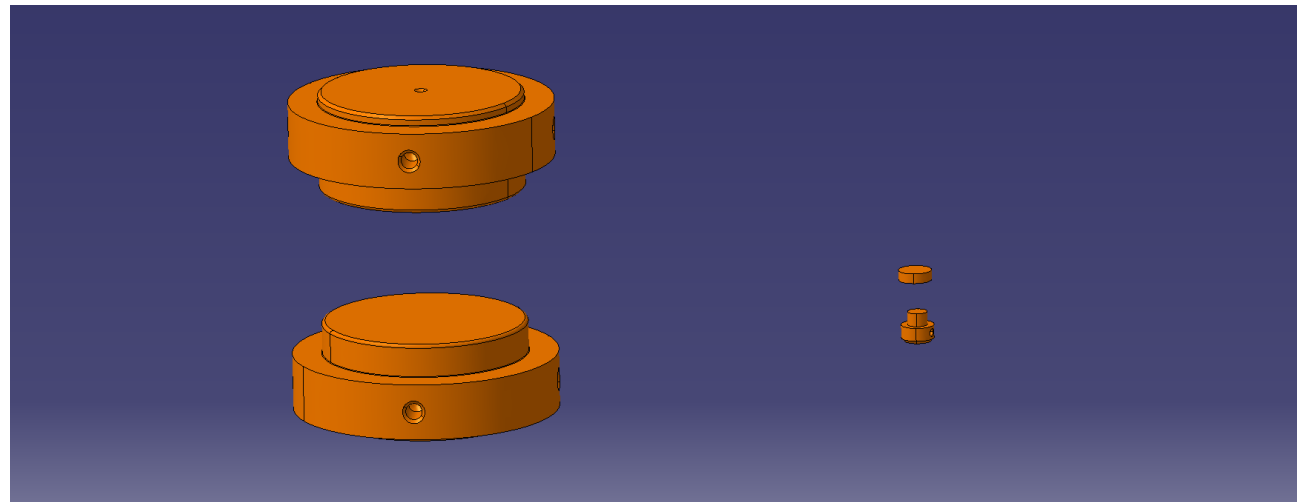
# Large electrodes system



Curent model



...courtesy of Enrique Rodriguez Castro





# Large Electrode System (LES)

